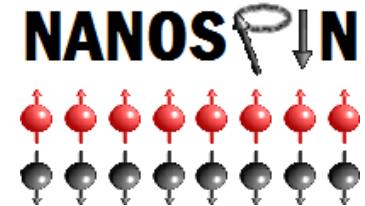




**SWISS  
CONTRIBUTION**

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under Grant PSPB-045/2010 from  
Switzerland through the Swiss Contribution



# Temperature dependency of Spin Hall Effect in Ta/CoFeB systems

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Józef Barnaś  
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Academy of Sciences



AGH University of  
Science and Technology

NANOSPIN Summerizing meeting

1  
11-12 July 2016



# Presentation outline

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1. Spin Hall effect (SHE) - short introduction
2. Sample structure (Ta/CoFeB) and characterization
  - a. Structural properties and resistivity
  - b. Magnetic properties and Dead Layer
3. Spin Hall effect: harmonic voltage measurement
4. SHE in Ta/CoFeB with perpendicular anisotropy

## Short summary I

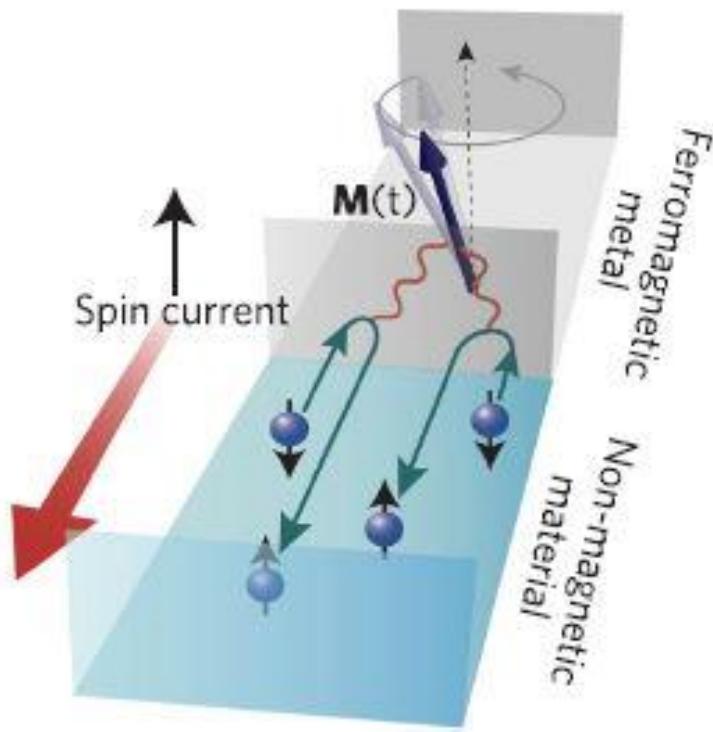
5. Sample structure and SHE in W/CoFeB with perpendicular anisotropy

## Short summary II

6. SHE in structures with in-plane anisotropy

## Short summary III

# Spin Hall effect



K. Ando, et al.,  
J. Appl. Phys. 109, 103913 (2011)

**Spin Hall angle  $\theta_{SH}$**  is a spin current density to charge current ratio:

$$\theta_{SH} = \left( \frac{\hbar J_s / 2e}{J_e} \right)$$

## Key parameters:

**Spin diffusion length  $\lambda$**  is the mean distance that electrons diffuse between spin-flipping collisions.

Topological insulators  
SHE induced by iridium impurities in copper

# Spin Hall effect

**L. Liu et al. Science 336, 555 (2012)**

Ta 8 nm/CoFeB 4 nm:  $\Theta_{SH} = 0.15$ ;  $\rho = 190 \text{ } [\mu\Omega \cdot \text{cm}]$

Ta 4 nm/CoFeB 1 nm:  $\Theta_{SH} = 0.12$

**Q. Hao Phys. Rev. B 91, 224413 (2015)**

Ta 4 nm/ CoFeB 1 nm:  $\Theta_{SH} = 0.11$ ;  $\rho = 200 \text{ } [\mu\Omega \cdot \text{cm}]$

**C. Zhang et al. Appl. Phys. Lett. 103, 262407 (2013)**

Ta 2.5 nm/ CoFeB 1 nm:  $\Theta_{SH} = 0.03$ ;  $\rho = \text{[}\mu\Omega \cdot \text{cm}$

**Allen et al. Phys. Rev. B 91, 144412 (2015)**

Ta 1-8 nm/ CoFeB 4 nm:  $\Theta_{SH} = 0.11$ ;  $\rho = 185 \text{ } [\mu\Omega \cdot \text{cm}]$

**Avci et al. Phys. Rev. B 89, 214419 (2014)**

Ta 1-8 nm/ CoFeB 4 nm:  $\Theta_{SH} = 0.08$ ;  $\rho = 185 \text{ } [\mu\Omega \cdot \text{cm}]$

**Spin diffusion lenght:  $\lambda_{Ta} = 1.2 \text{ nm} \sim 2.5 \text{ nm}$**

Kwon et al. APL 107, 022401 (2015); Allen et al. PRB 91, 144412 (2015)

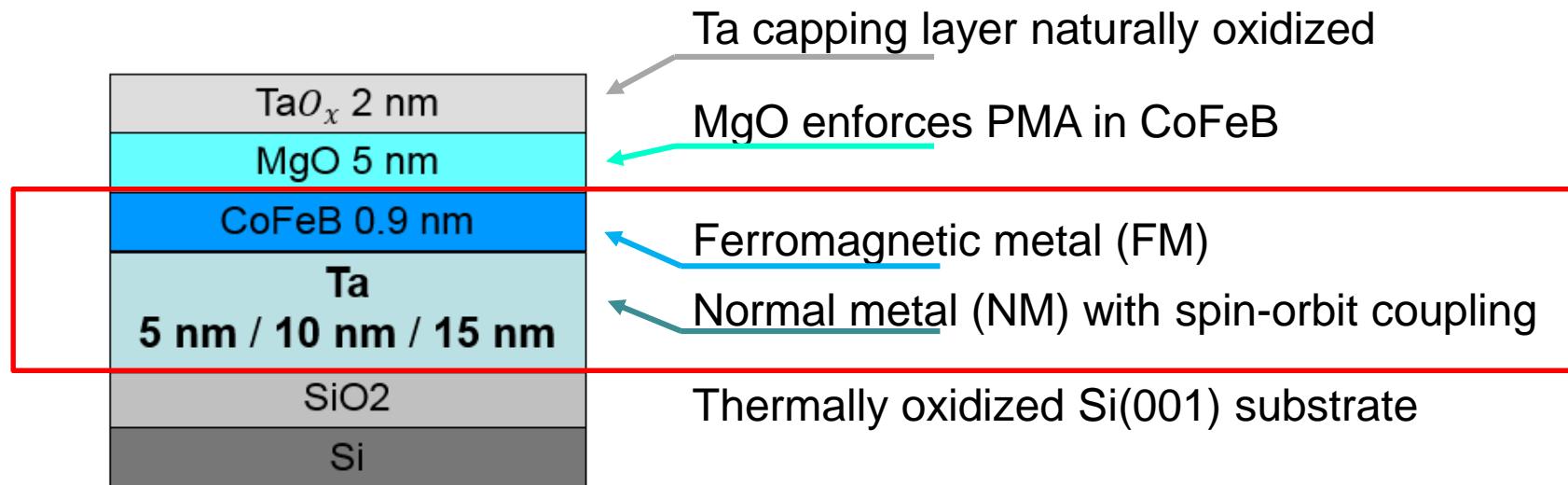
## Aim:

- Explain literatures discrepancy
- Investigate an influence of the microstructure
- Examine the interface between normal metal and ferromagnet

# Samples structure

Annealed in 330°C for 20min:

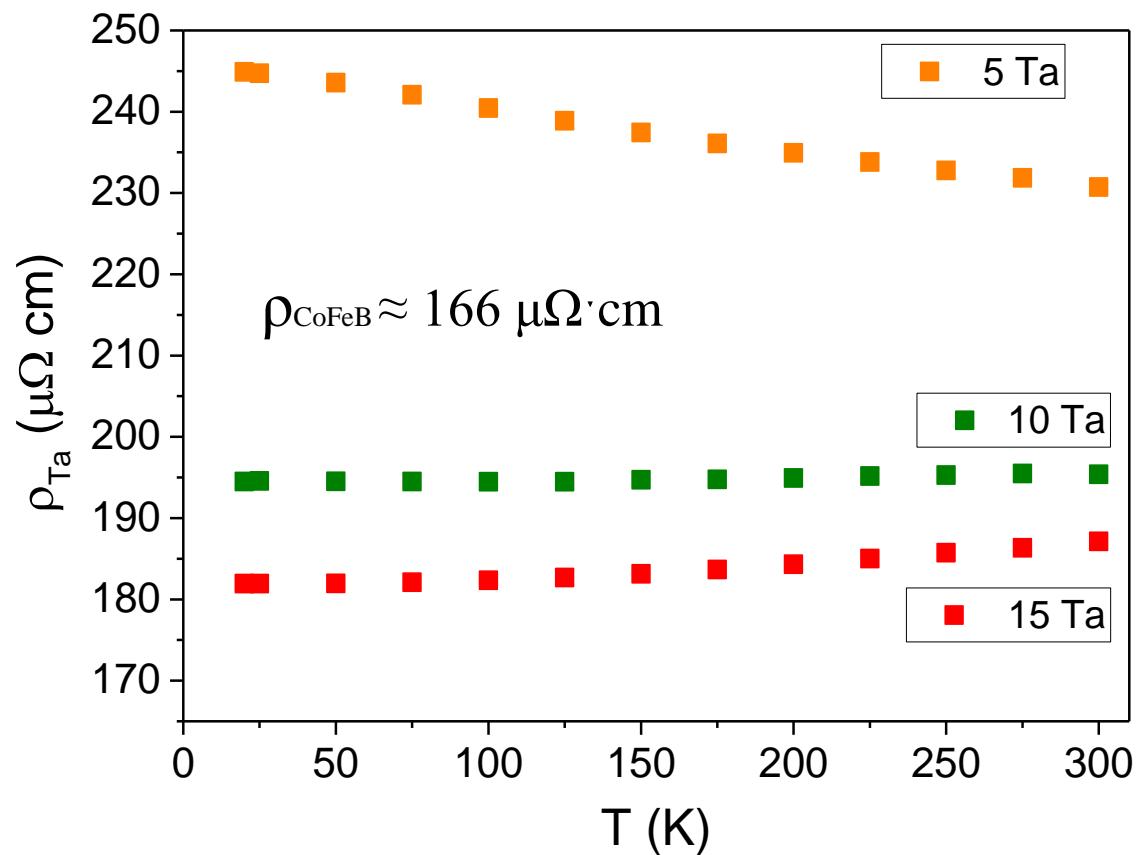
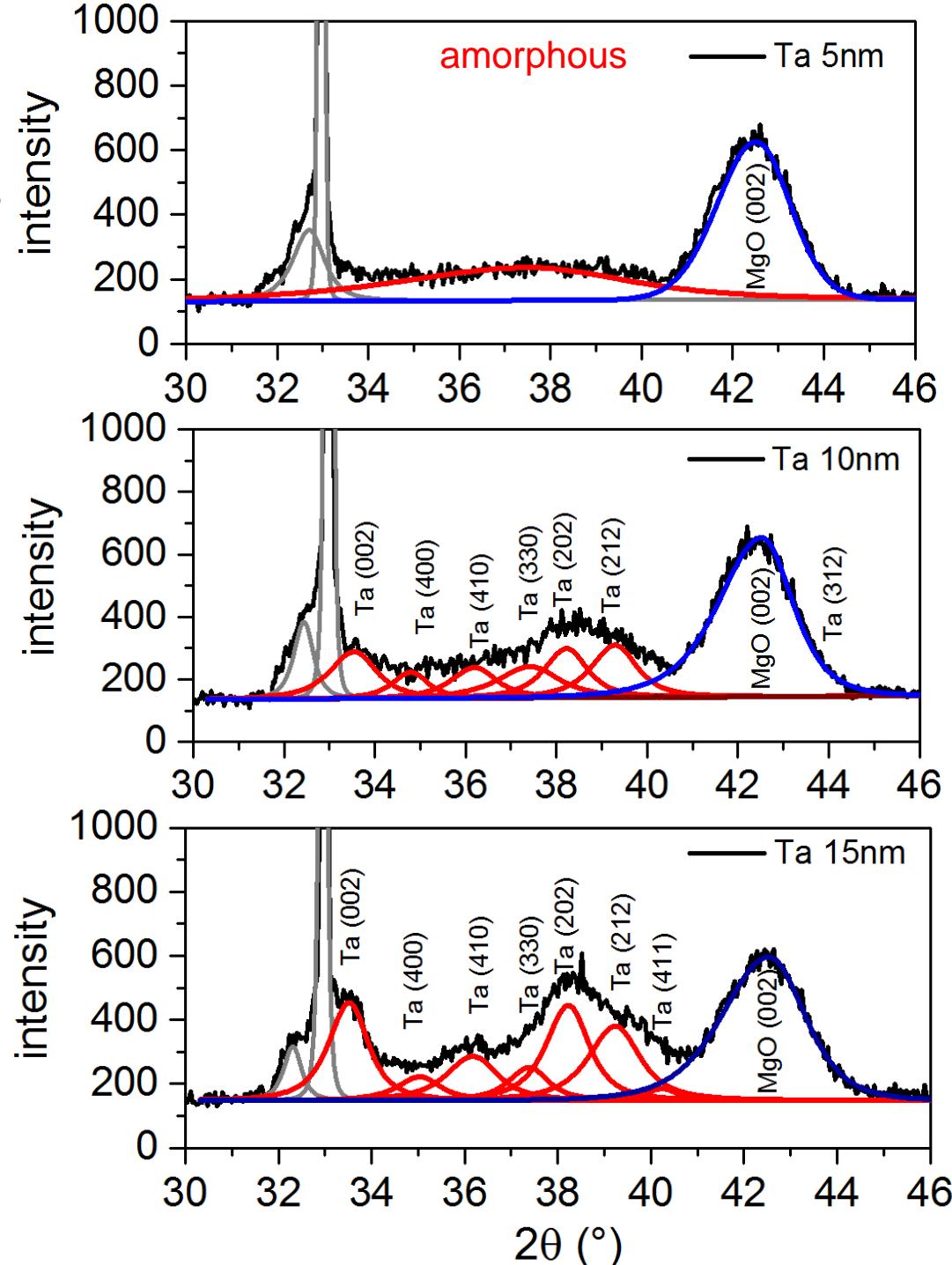
**d Ta / 0.91 CoFeB / 5 MgO / TaO<sub>x</sub>**  
**d Ta = 5 nm, 10 nm, 15 nm**



Deposited using sputtering method in Singulus  
Timaris PVD Cluster Tool System

PMA – perpendicular magnetic anisotropy

# Structural properties and resistivity

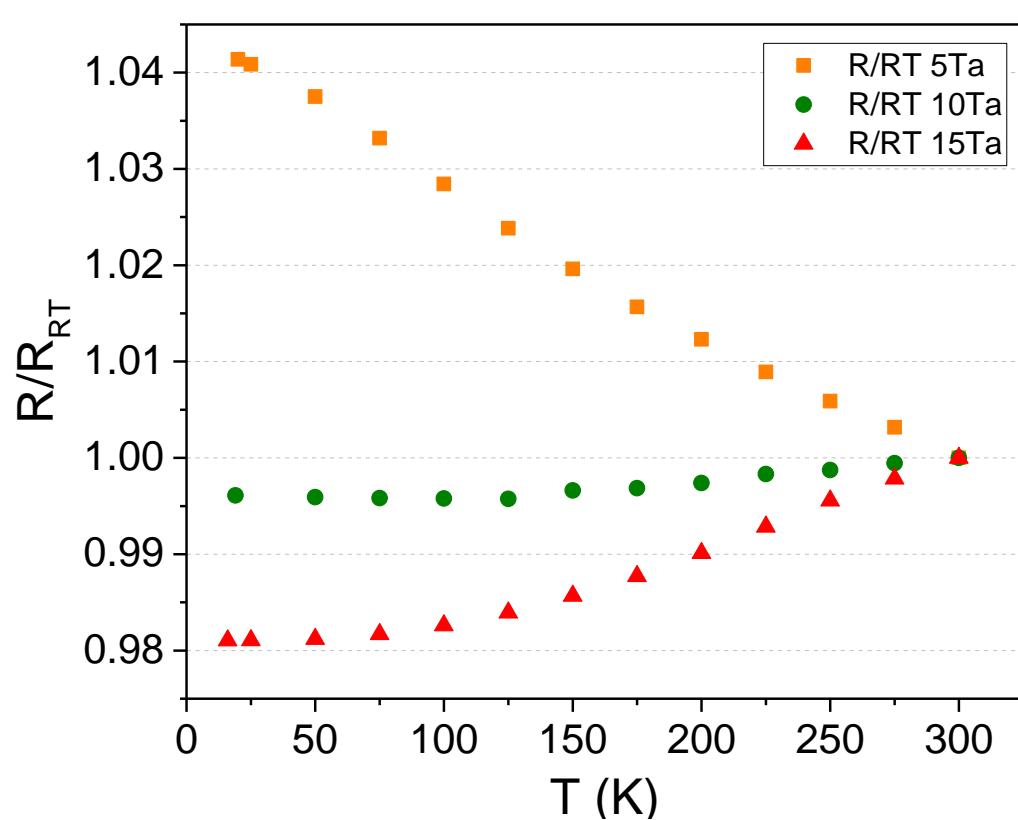
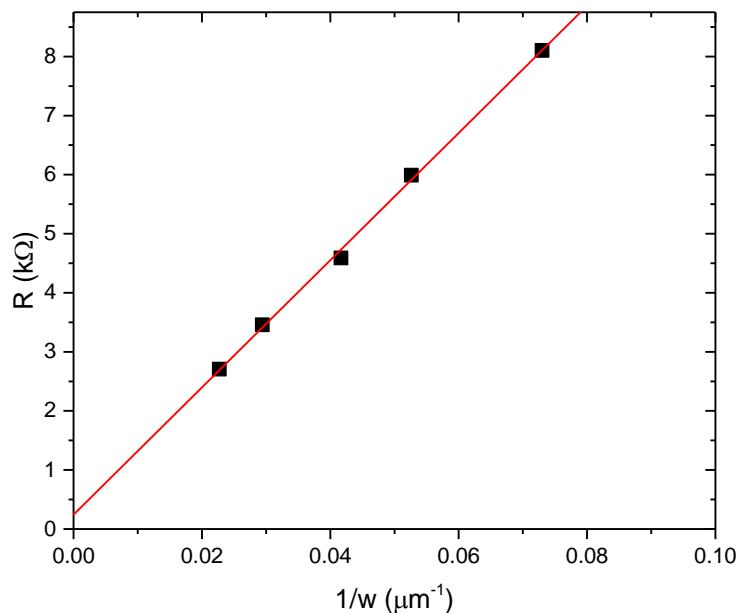
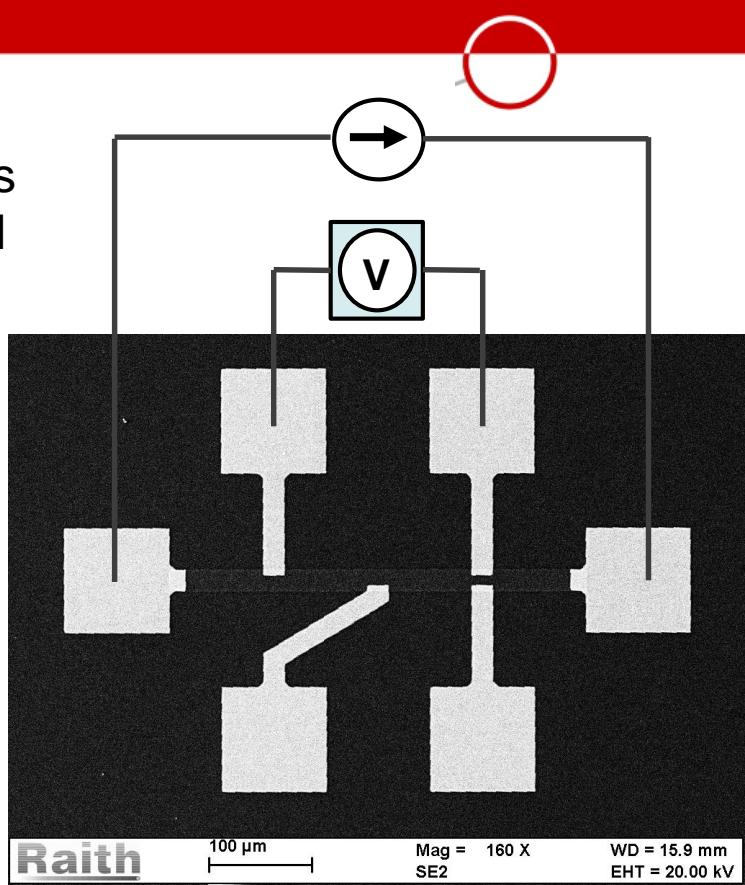


Absence of  $\alpha$ -tantalum phase

- High resistivity (100–200  $\mu\Omega \text{cm}$ )  $\beta$ -tantalum
- Amorphous films ( $>200 \mu\Omega \text{cm}$ )

# Structural properties and resistivity

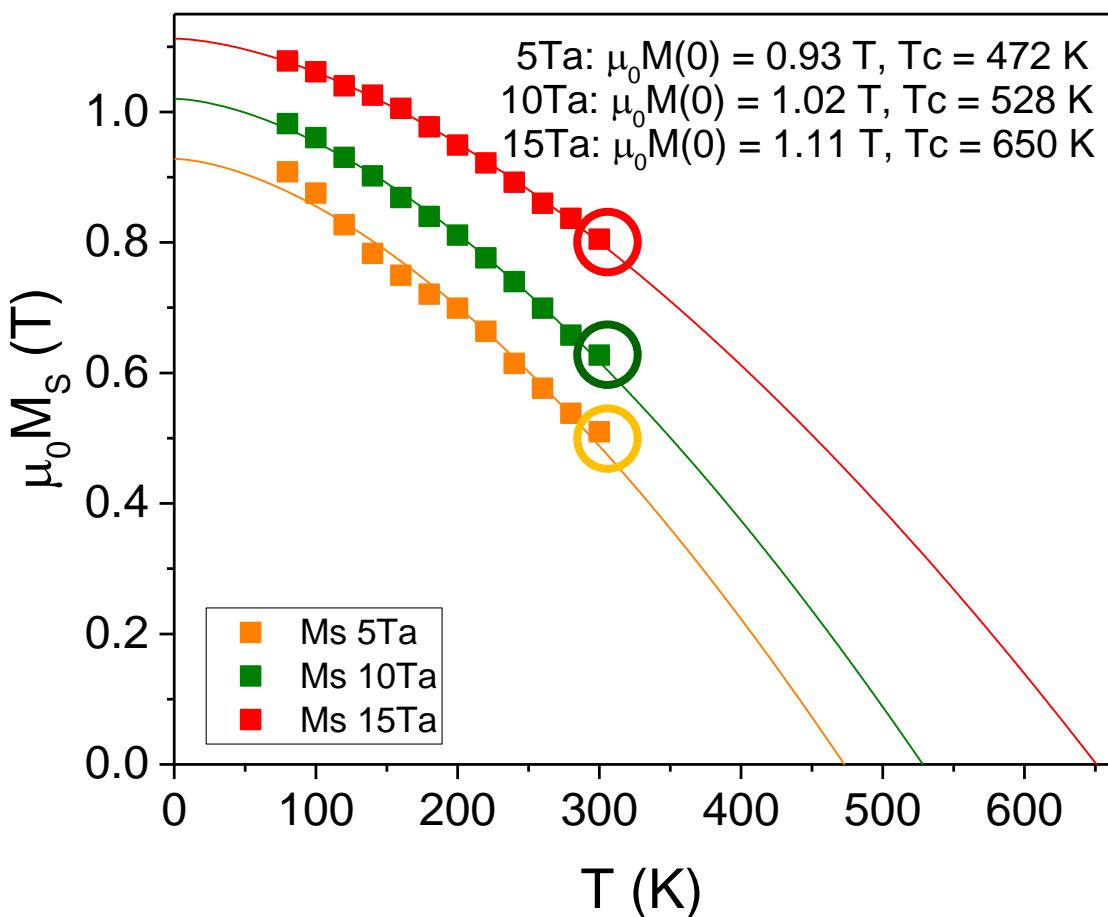
4-points method



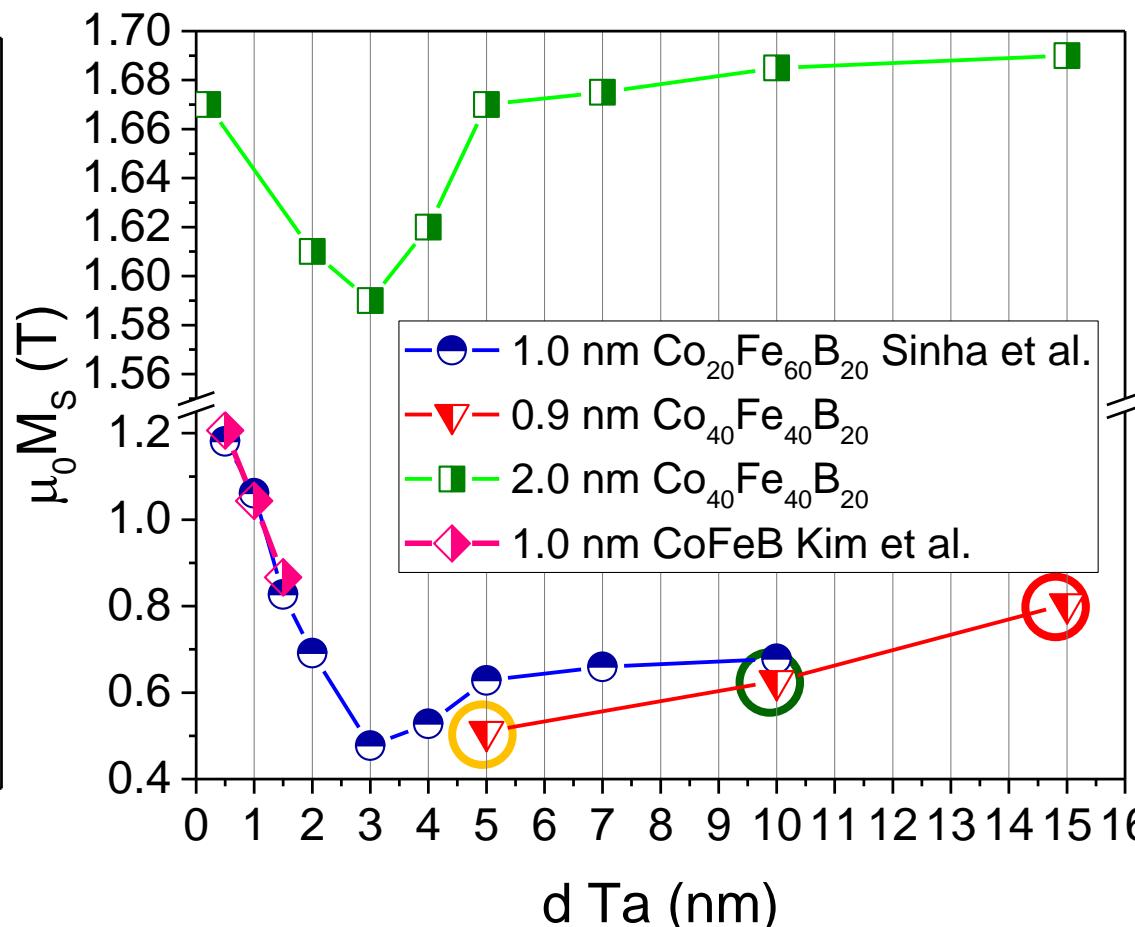
## Absence of $\alpha$ -tantalum phase

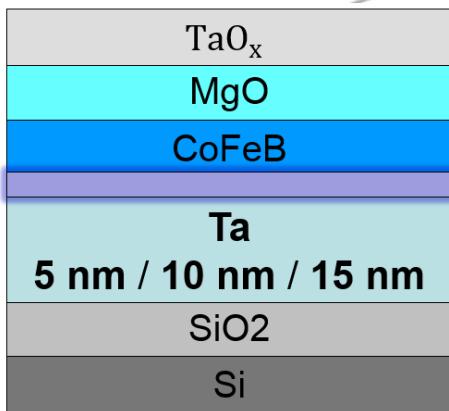
- High resistivity (100–200  $\mu\Omega\text{cm}$ )  $\beta$ -tantalum
- Amorphous films ( $>200 \mu\Omega\text{cm}$ )

# Magnetic properties



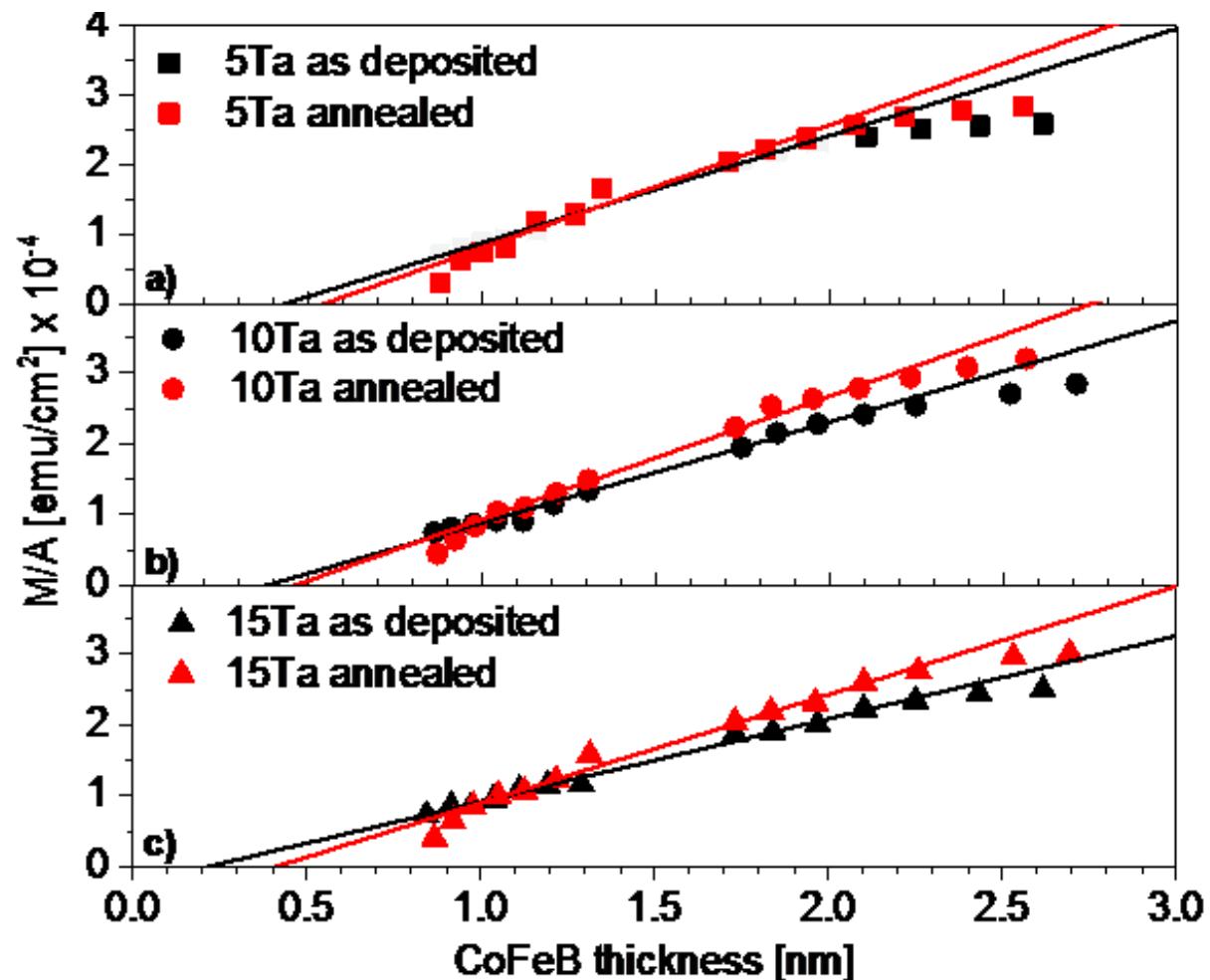
$$\text{Bloch law: } \mu_0 M_S = M_0 (1 - (T/T_c)^{3/2})$$





### Magnetic dead layer for T = 300 K

	5 nm Ta	10 nm Ta	15 nm Ta
AD [nm]	0.43 ( $\pm 0.03$ )	0.39 ( $\pm 0.04$ )	0.22 ( $\pm 0.03$ )
AN [nm]	0.52 ( $\pm 0.05$ )	0.50 ( $\pm 0.04$ )	0.40 ( $\pm 0.03$ )



Nominal CoFeB thickness  $t_{\text{CoFeB}} = 0.9 \text{ nm}$ , PMA after annealing

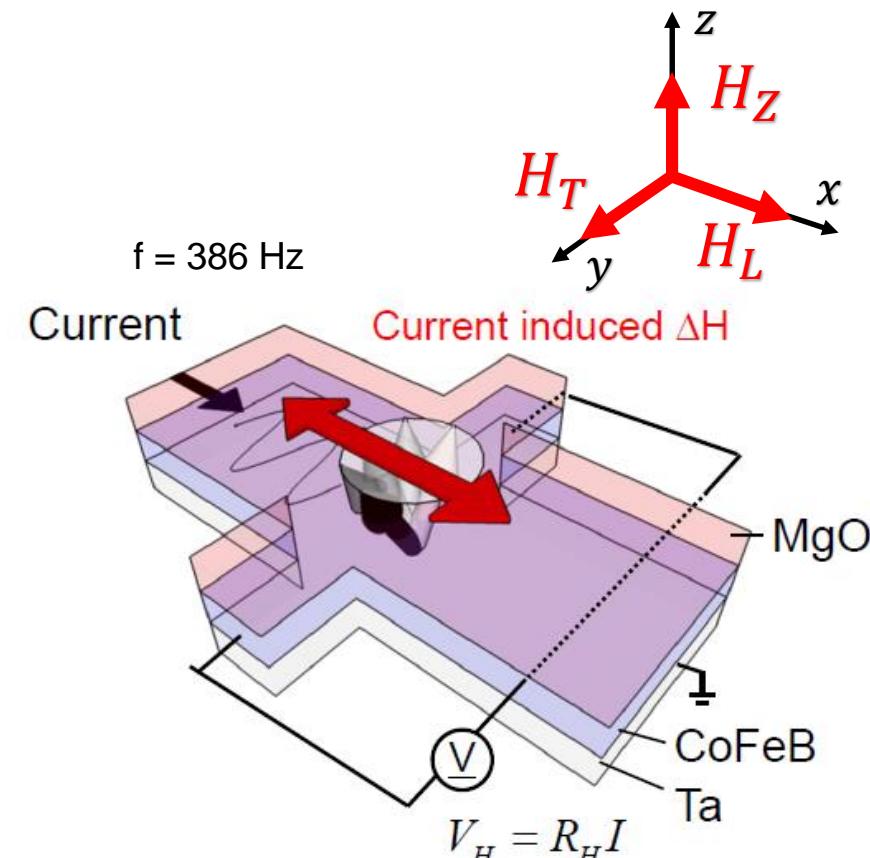
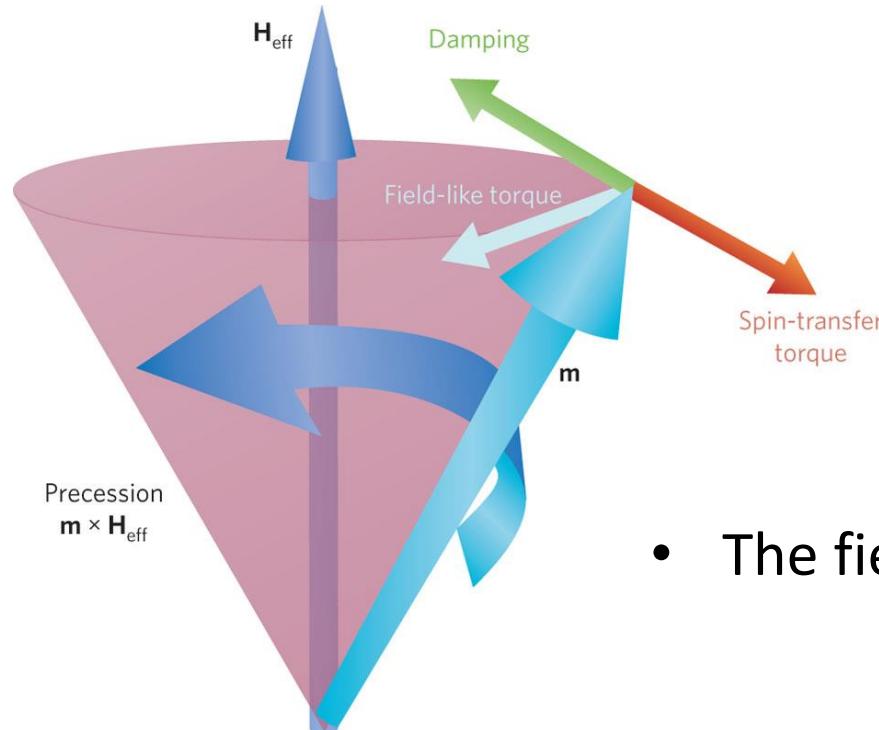
# Harmonic Hall voltage measurement

Lock-in amplifier detection:  
modulation of the input signal

Longitudinal and transverse effective fields:

$$\Delta H_{L,T} = -2 \frac{\partial V_{2\omega}/\partial H_{L,T}}{\partial^2 V_\omega/\partial H_{L,T}^2}$$

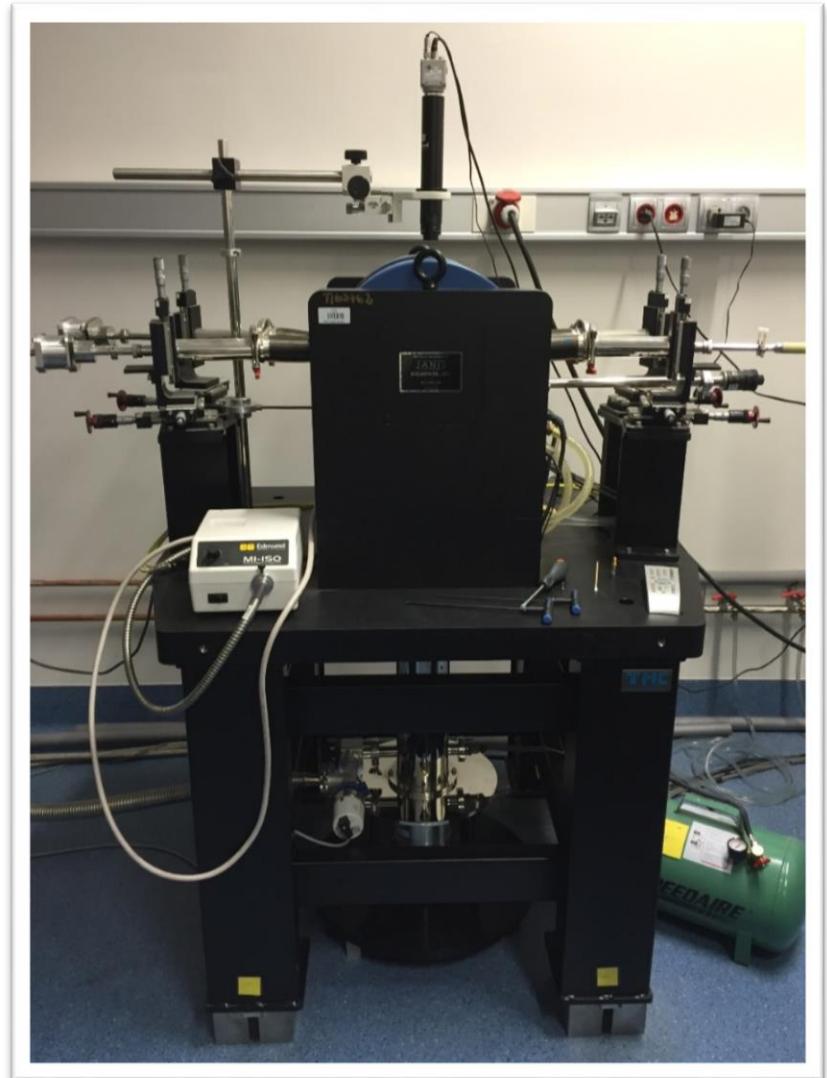
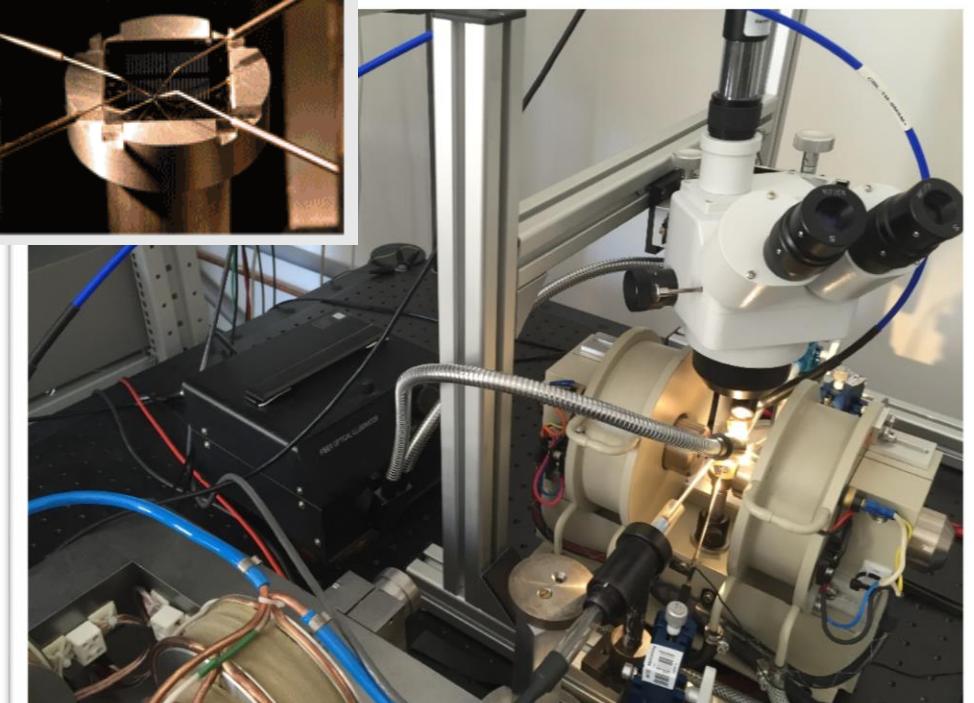
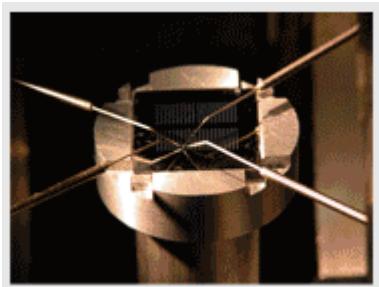
$$\Delta R_P/\Delta R_A \ll 1$$



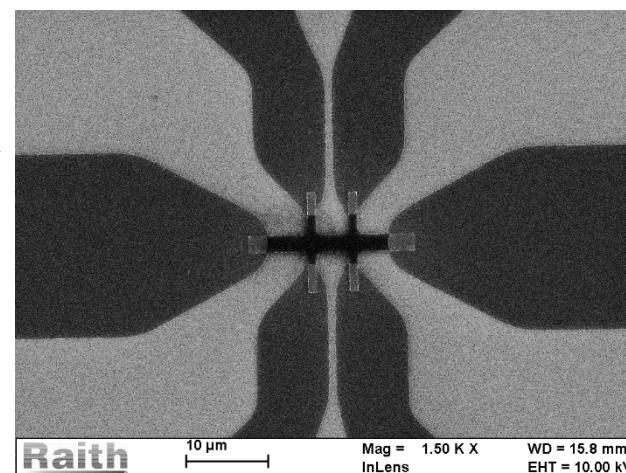
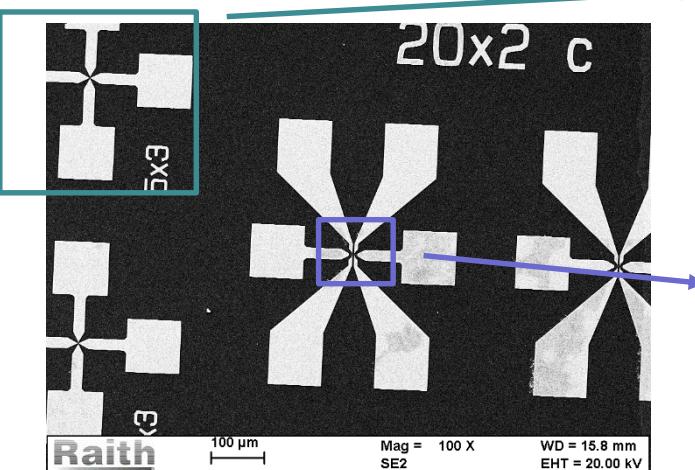
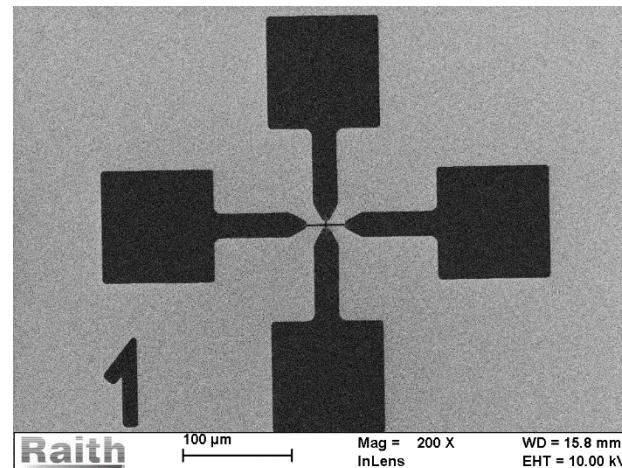
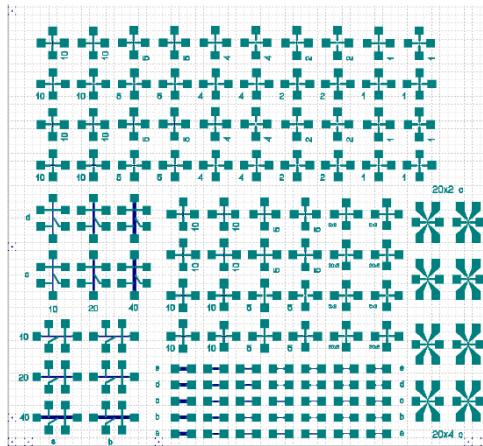
J. Kim et al. PRB 89, 174424 (2014)

- The field-like and antidamping-like spin torques

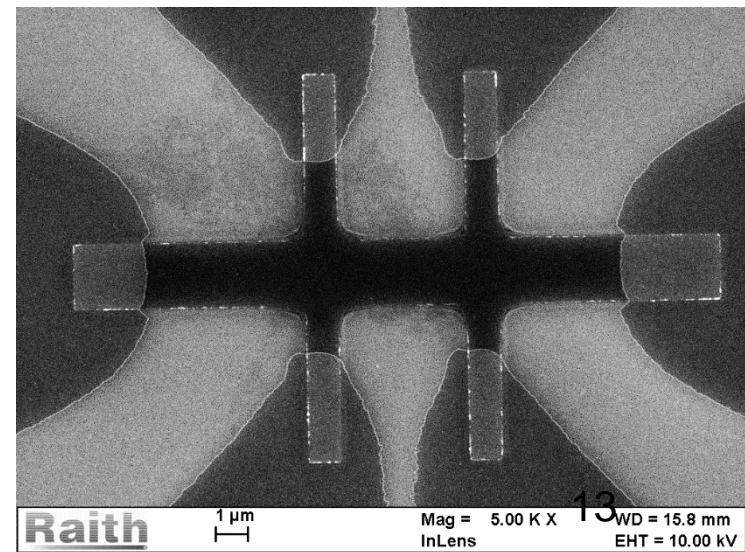
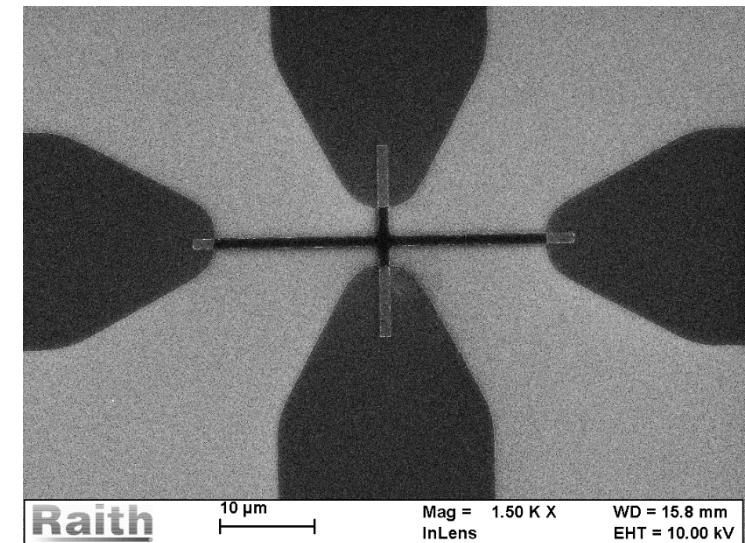
# Harmonic Hall voltage measurements



# Hall $\mu$ -bars

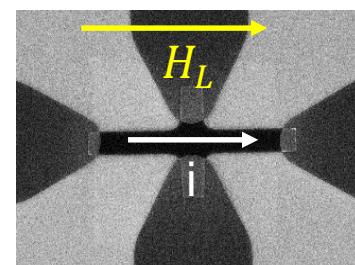


20 µm x 2 µm

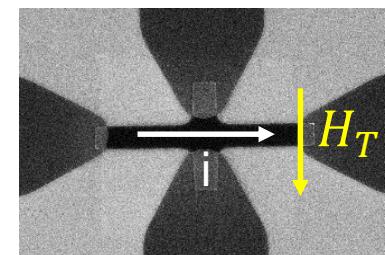


# Harmonic Hall voltage measurements

Longitudinal  
in-plane field



Transverse  
in-plane field

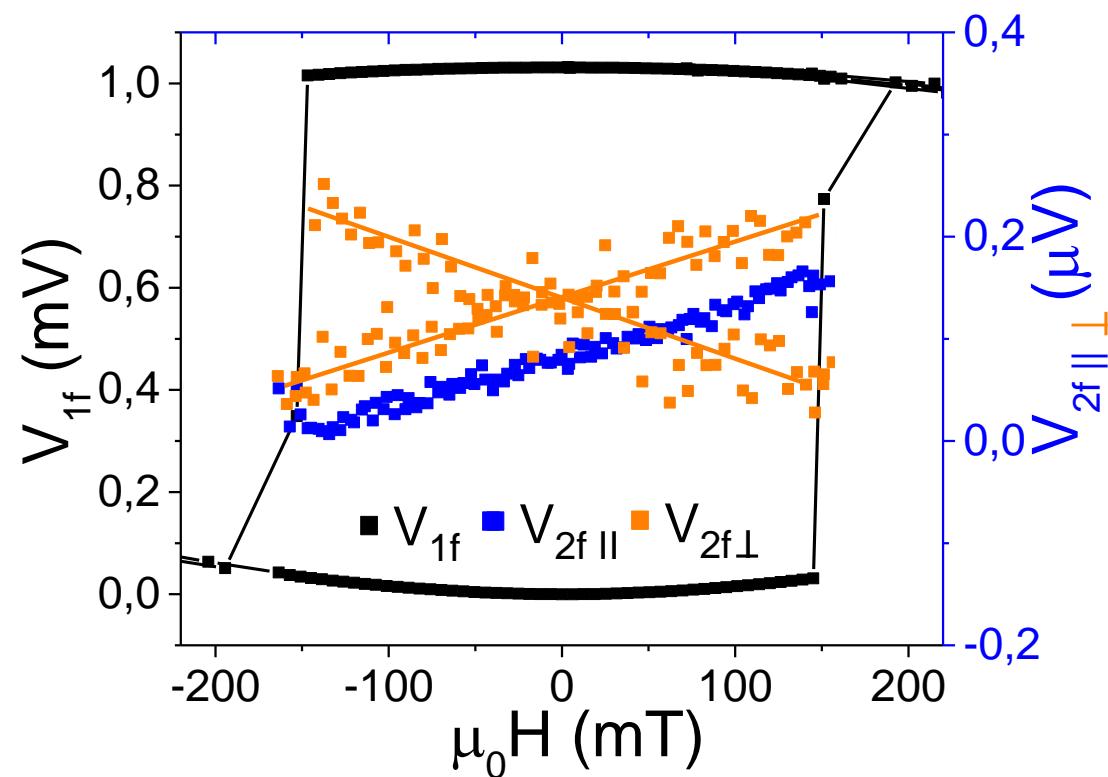


$$\Delta R_P / \Delta R_A < 1\%$$

$$\Delta H_{L,T} = -2 \frac{\partial V_{2\omega} / \partial H_{L,T}}{\partial^2 V_\omega / \partial H_{L,T}^2}$$

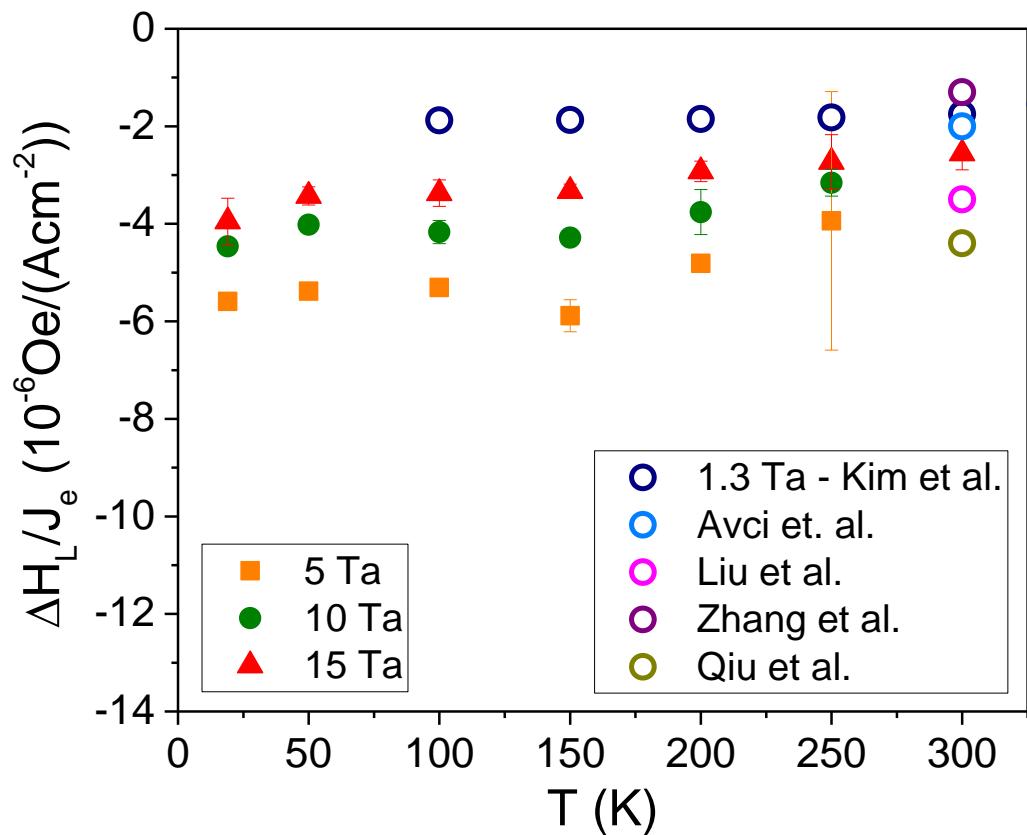
$\Delta H_T$  refers to  
field-like torque

$\Delta H_L$  refers to  
an antidamping-like torque

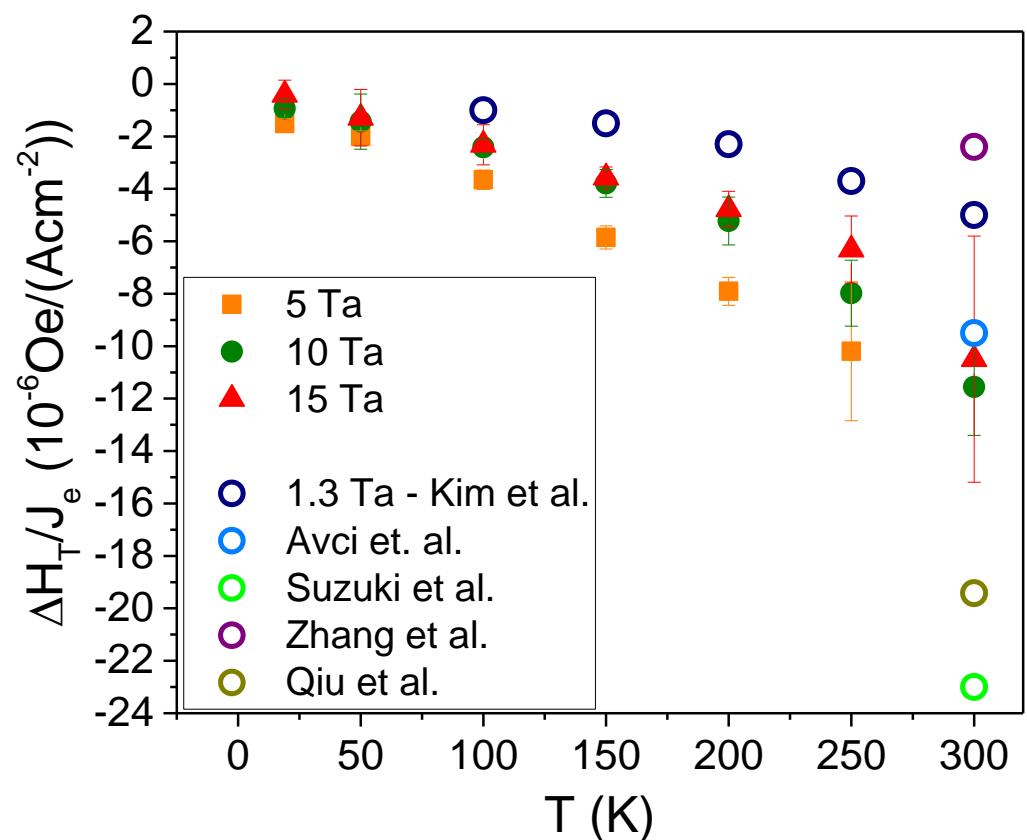


# SOT-induced effective fields

Longitudinal SOT-induced effective field



Transverse SOT-induced effective field



J. Kim et al. PRB **89**, 174424 (2014) Ta(1.3 nm)/Co<sub>20</sub>Fe<sub>60</sub>B<sub>20</sub> (1 nm)

C. Avci et al. PRB **89**, 214419 (2014) Ta(3 nm)/Co<sub>60</sub>Fe<sub>20</sub>B<sub>20</sub> (0.9 nm)

L. Liu et al. Ta(6 nm)/CoFeB(1 nm)

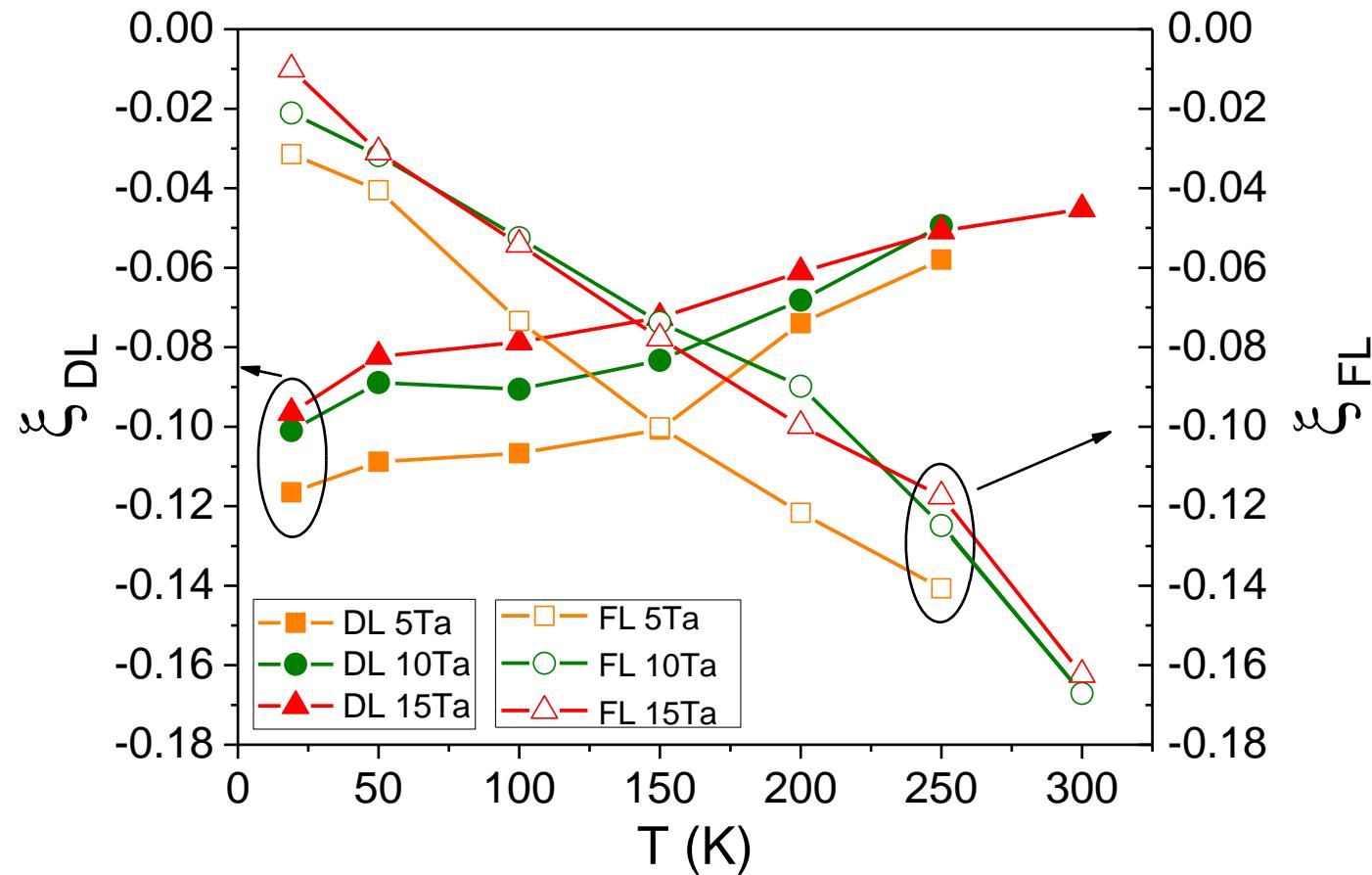
T. Suzuki et al. Appl. Phys. Lett. **98**, 142505 (2011) Ta(1 nm)/Co<sub>40</sub>Fe<sub>40</sub>B<sub>20</sub> (1 nm)

C. Zhang et al. Appl. Phys. Lett. **103**, 262407 (2013) Ta(2.5 nm)/CoFeB(1 nm)

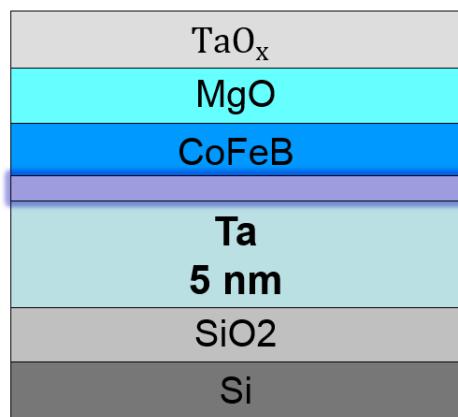
X. Qiu et al. Scientific Reports 4 : 4491 (2014) Ta(2 nm)/Co<sub>40</sub>Fe<sub>40</sub>B<sub>20</sub> (0.8 nm)

# Spin Hall torque efficiencies

$$\xi_{DL/FL} = \Delta H_{L,T} \cdot 2e\mu_0 M_S t_{CoFeB} / J_e^{Ta} \cdot \hbar$$



From room temperature down to 150 K field-like torque is dominating.



Field-like torque

efficiency:  $\xi_{FL} = -\theta_{SH} \left( 1 - \frac{1}{\cosh(\frac{d}{\lambda_N})} \right) \frac{g_i}{(1 + g_r)^2 + g_i^2},$

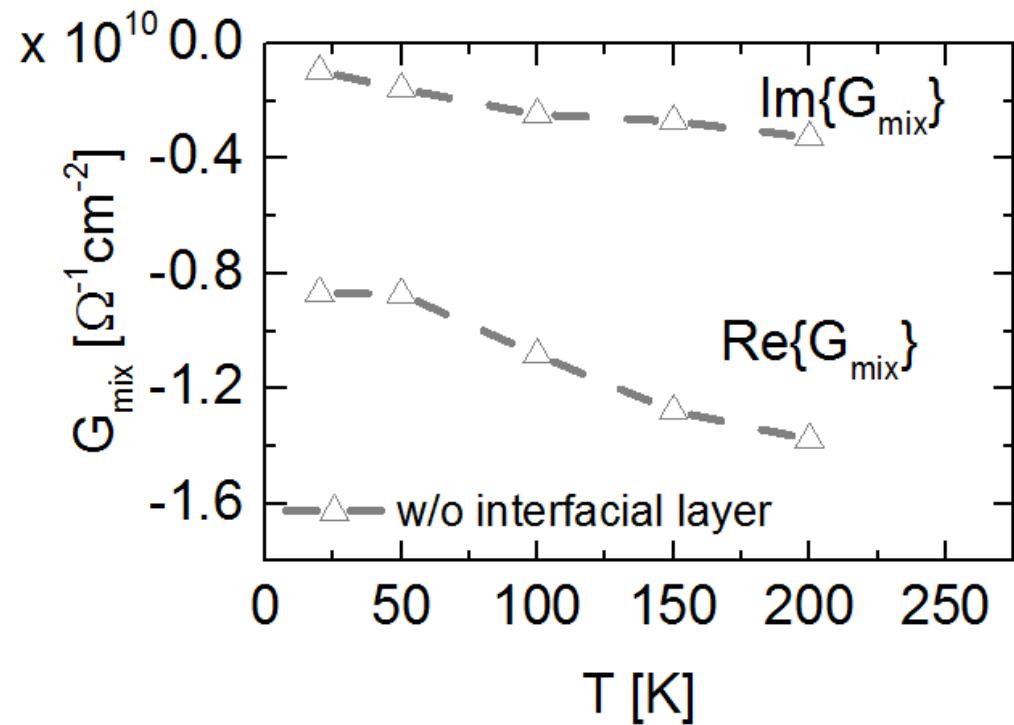
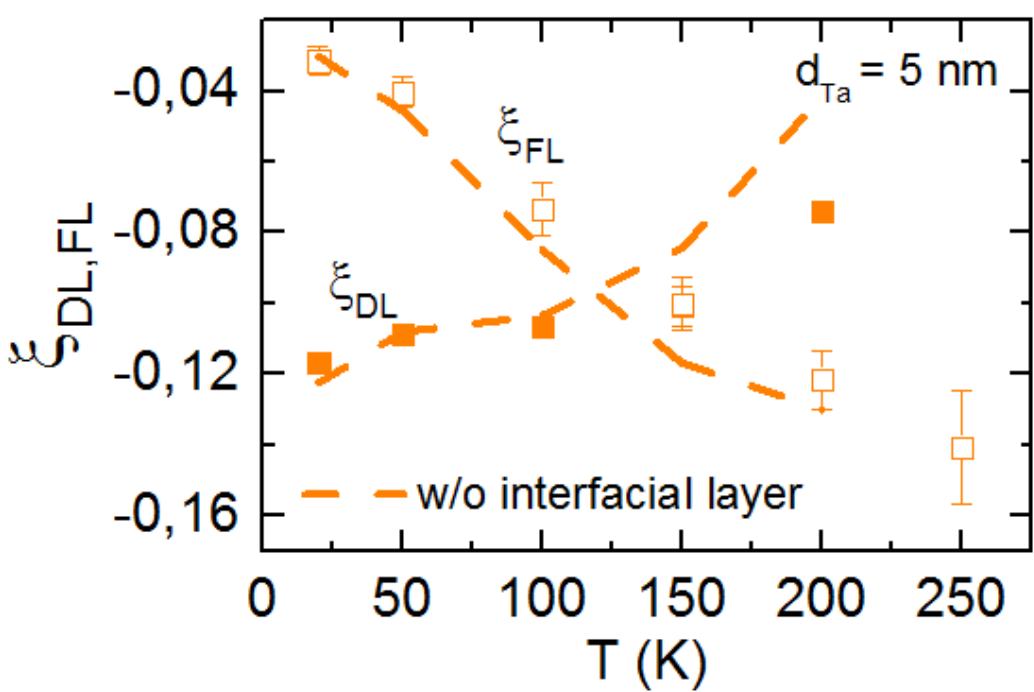
Damping-like torque

efficiency:  $\xi_{DL} = -\theta_{SH} \left( 1 - \frac{1}{\cosh(\frac{d}{\lambda_N})} \right) \frac{(1 + g_r)g_r + g_i^2}{(1 + g_r)^2 + g_i^2},$

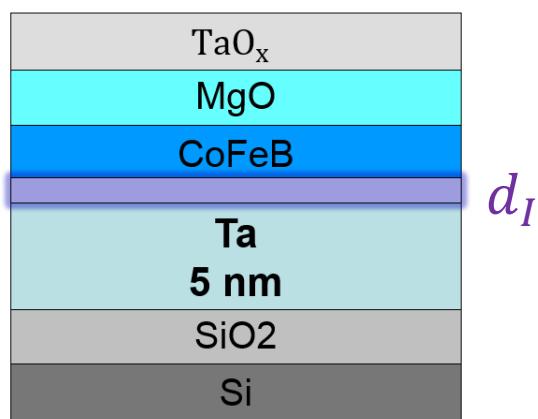
Mixing conductance:

$$g_{r,i} = G_{r,i} \rho_N \lambda_N \coth(d/\lambda_N)$$

Y-T. Chen et al. Phys.  
Rev. B 87, 144411 (2013)



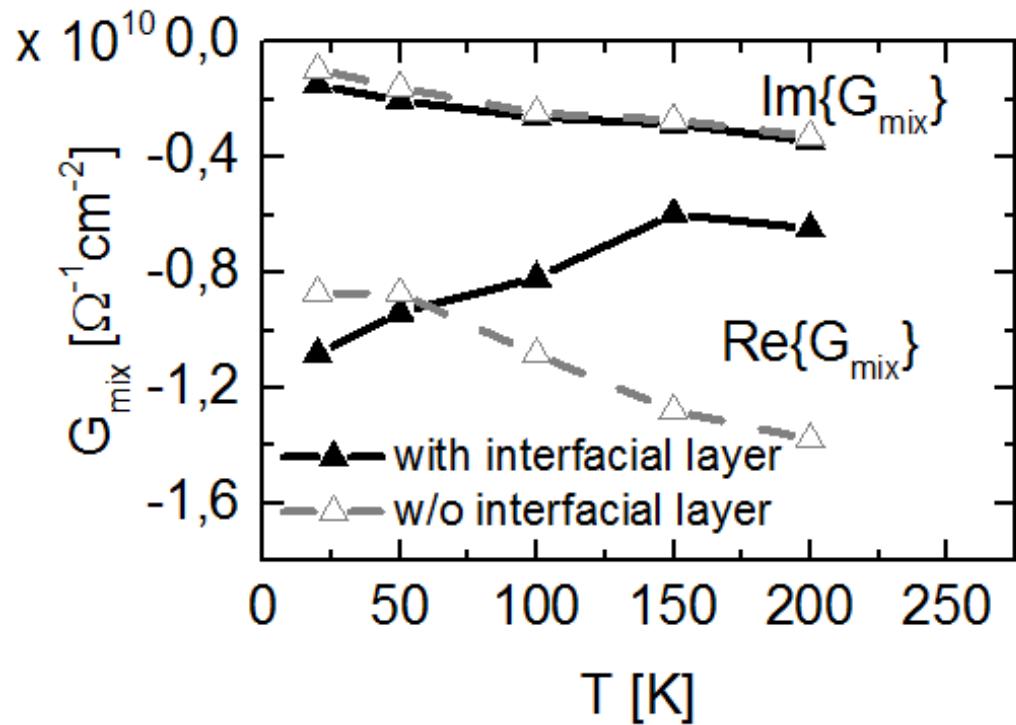
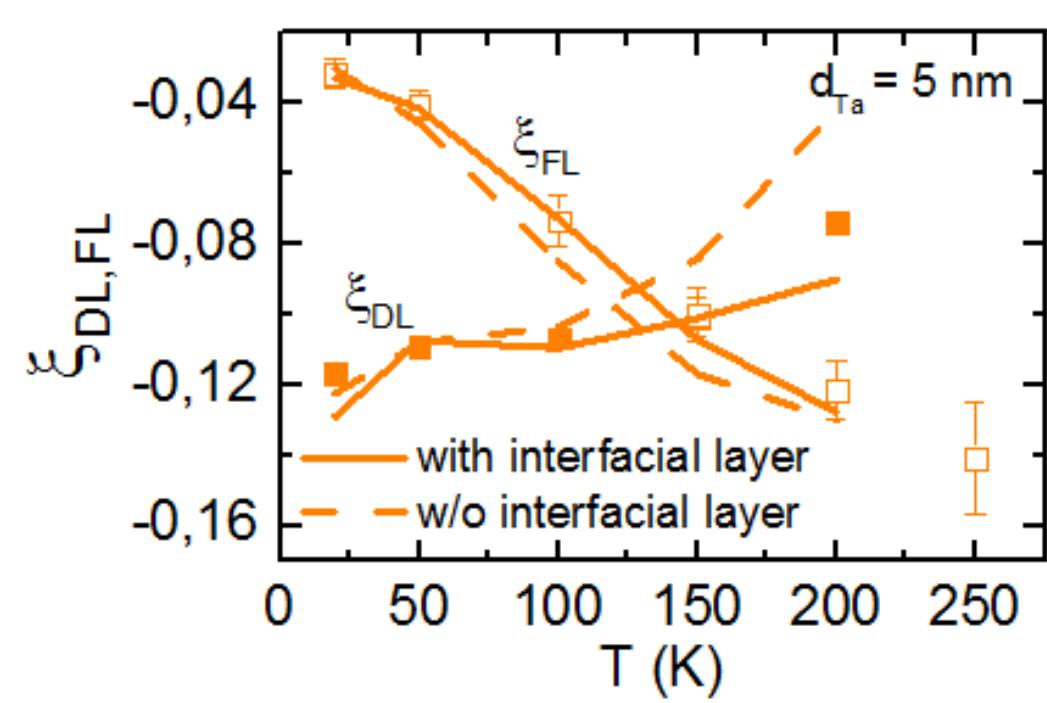
Spin diffusion lenght:  $\lambda_{Ta} = 2.5 \text{ nm}$   
 Allen et al. PRB **91**, 144412 (2015)



$$\xi_{DL} = -\theta_{SH} \frac{\tanh(\frac{d_N}{2\lambda_N}) \operatorname{csch}(\frac{d_I}{\lambda_I})}{\coth(\frac{d_N}{\lambda_N}) \coth(\frac{d_I}{\lambda_I}) + \frac{\rho_I \lambda_I}{\rho_N \lambda_N}} \frac{g_r (1 + g_r) + g_i^2}{(1 + g_r)^2 + g_i^2} m_z,$$

$$\xi_{FL} = -\theta_{SH} \frac{\tanh(\frac{d_N}{2\lambda_N}) \operatorname{csch}(\frac{d_I}{\lambda_I})}{\coth(\frac{d_N}{\lambda_N}) \coth(\frac{d_I}{\lambda_I}) + \frac{\rho_I \lambda_I}{\rho_N \lambda_N}} \frac{g_i}{(1 + g_r)^2 + g_i^2},$$

$$g_{r,i} = 2G_{r,i} \frac{\coth(\frac{d_N}{\lambda_N}) \coth(\frac{d_I}{\lambda_I}) + \frac{\rho_I \lambda_I}{\rho_N \lambda_N}}{\frac{1}{\rho_I \lambda_I} \coth(\frac{d_N}{\lambda_N}) + \frac{1}{\rho_N \lambda_N} \coth(\frac{d_I}{\lambda_I})}$$



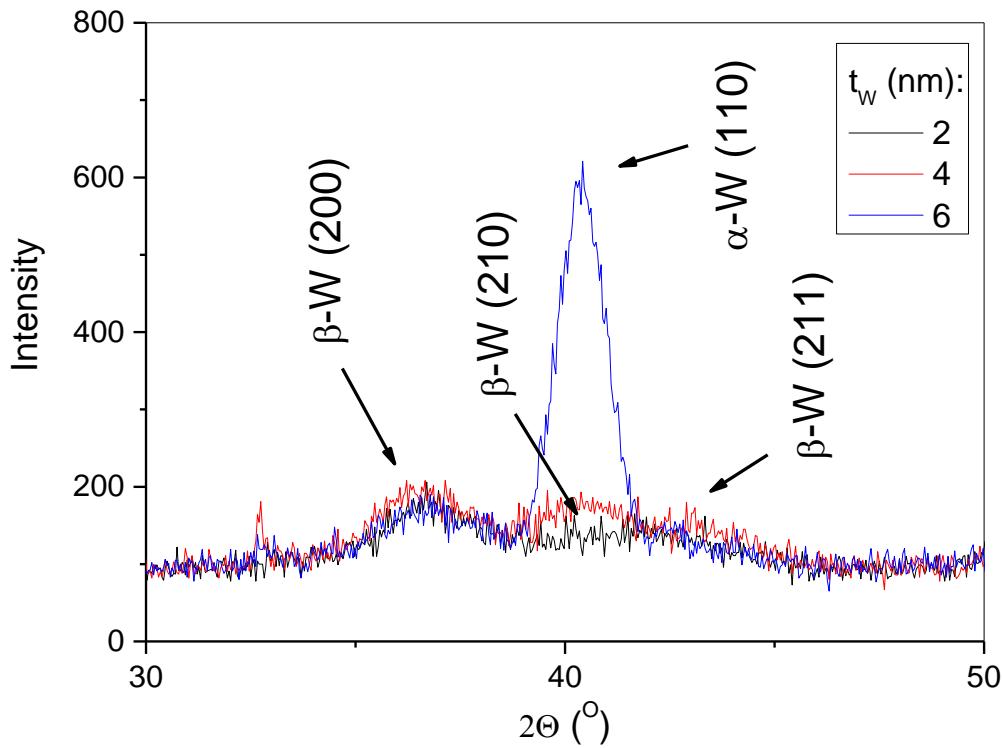
## SHE in Ta/CoFeB: summary

- ❖ Significant changes in the structure of Ta  
Amorphous 5 nm Ta with high resistivity ( $240 \mu\Omega\cdot\text{cm}$ ), disoriented  $\beta$ -phase structure for 10 nm and 15 nm Ta
- ❖ Characteristic change of the dead layer (DL) thickness in function of the Ta thickness  
Maximum DL/ minimum  $M_s$  for 5 nm Ta
- ❖ Both Spin Hall torque efficiencies higher for sample with 5 nm of Ta  
Domination of antidamping torque below 150 K
- ❖ Still remain open questions  
Spin diffusion lenght in Ta and in the interface

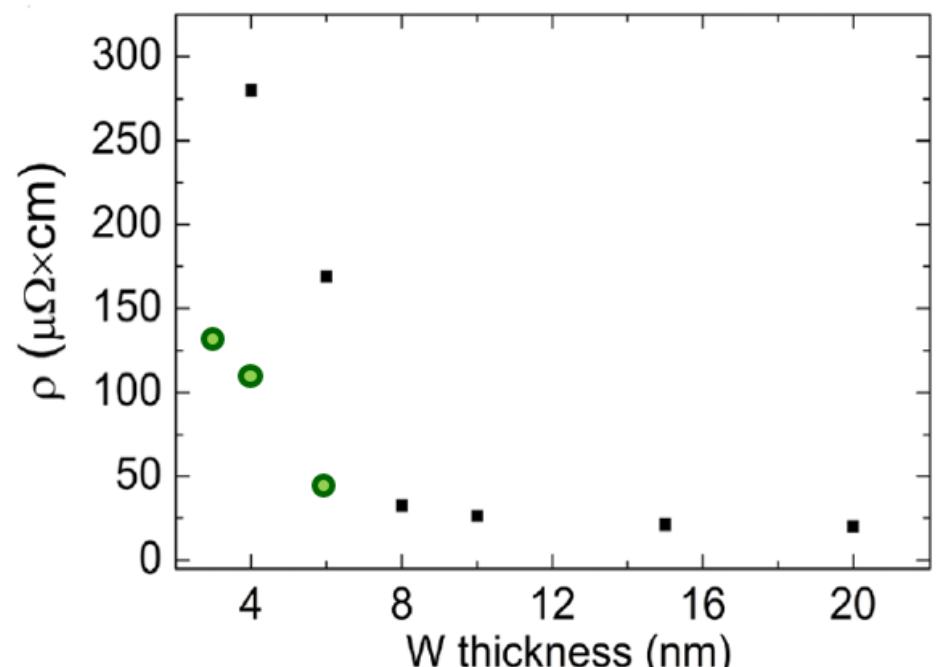
# Spin Hall torque efficiencies in W

Ta <sub>O<sub>x</sub></sub> 2 nm
MgO 2.5 nm
CoFeB 1.3 nm
W 2 nm / 4 nm / 6 nm
SiO <sub>2</sub>
Si

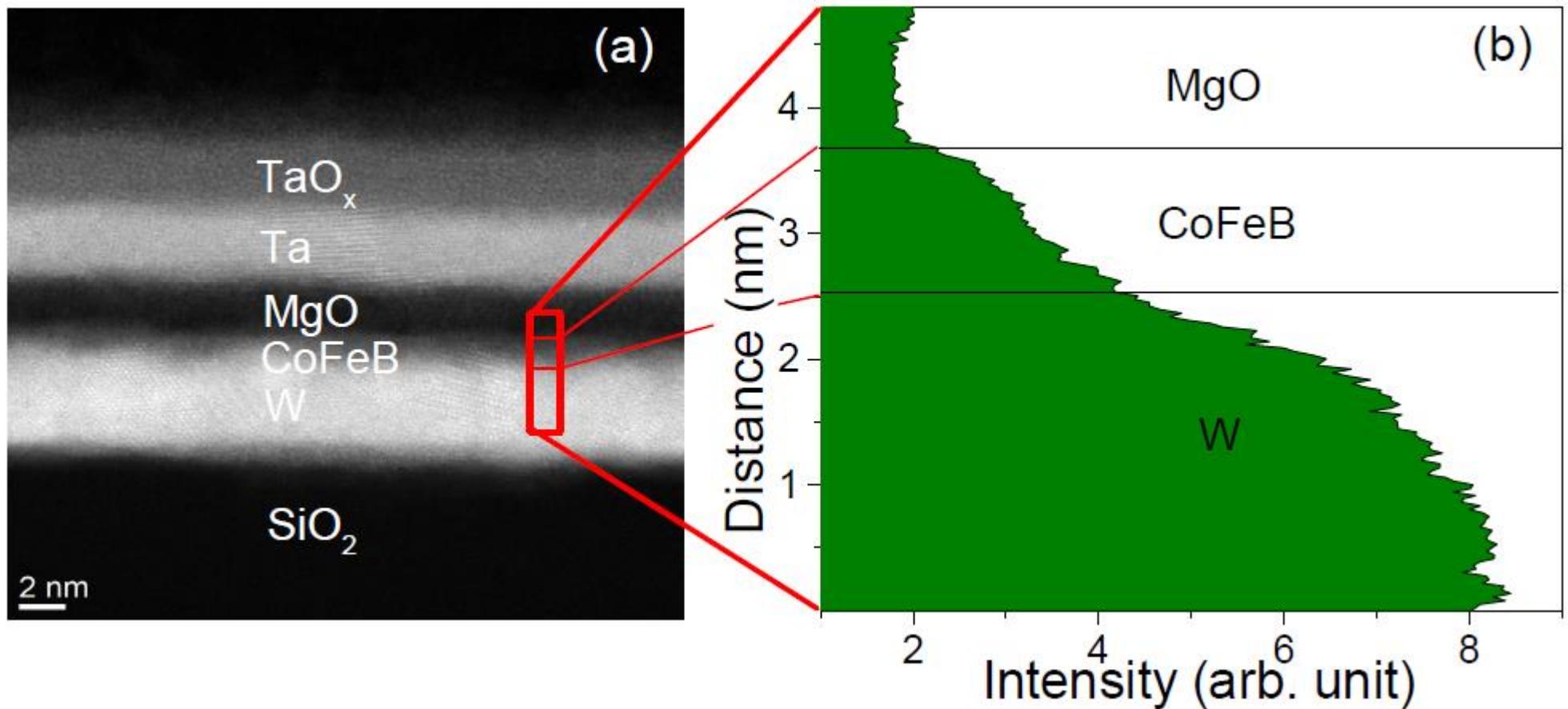
W( $t_W$ )/Co<sub>12</sub>Fe<sub>68</sub>B<sub>20</sub> (1.3)/MgO(2.5)/Ta(4)  
 $t_W = 2, 4, \text{ and } 6 \text{ nm}$

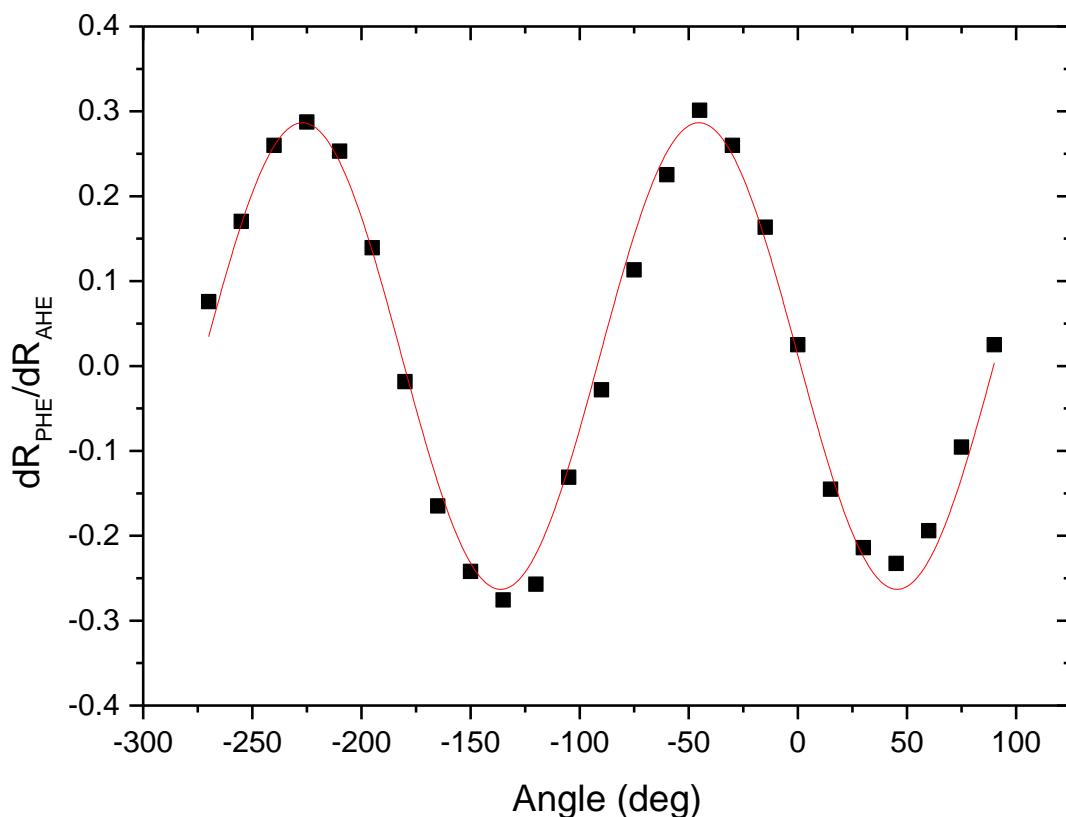


$t_W$ (nm)	2	4	6
$\rho_W (\mu\Omega \cdot \text{cm})$	128	105	36



Z-contrast TEM image of fabricated multilayer stack (a) and line scan profile along vertical axis (b), indicating chemical intermixing at the interface between CoFeB and W.

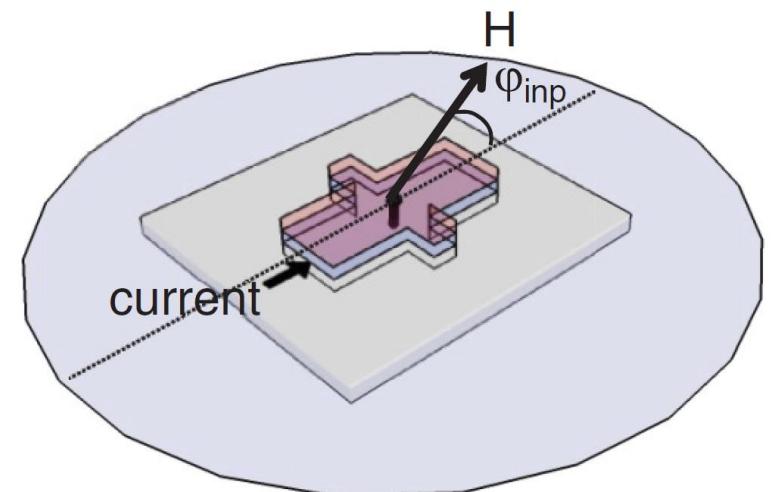




$$\Delta R_P / \Delta R_A = 30 \%$$

For Ta  $\Delta R_P / \Delta R_A < 5\%$

# Planar Hall effect in W



Effective fields:

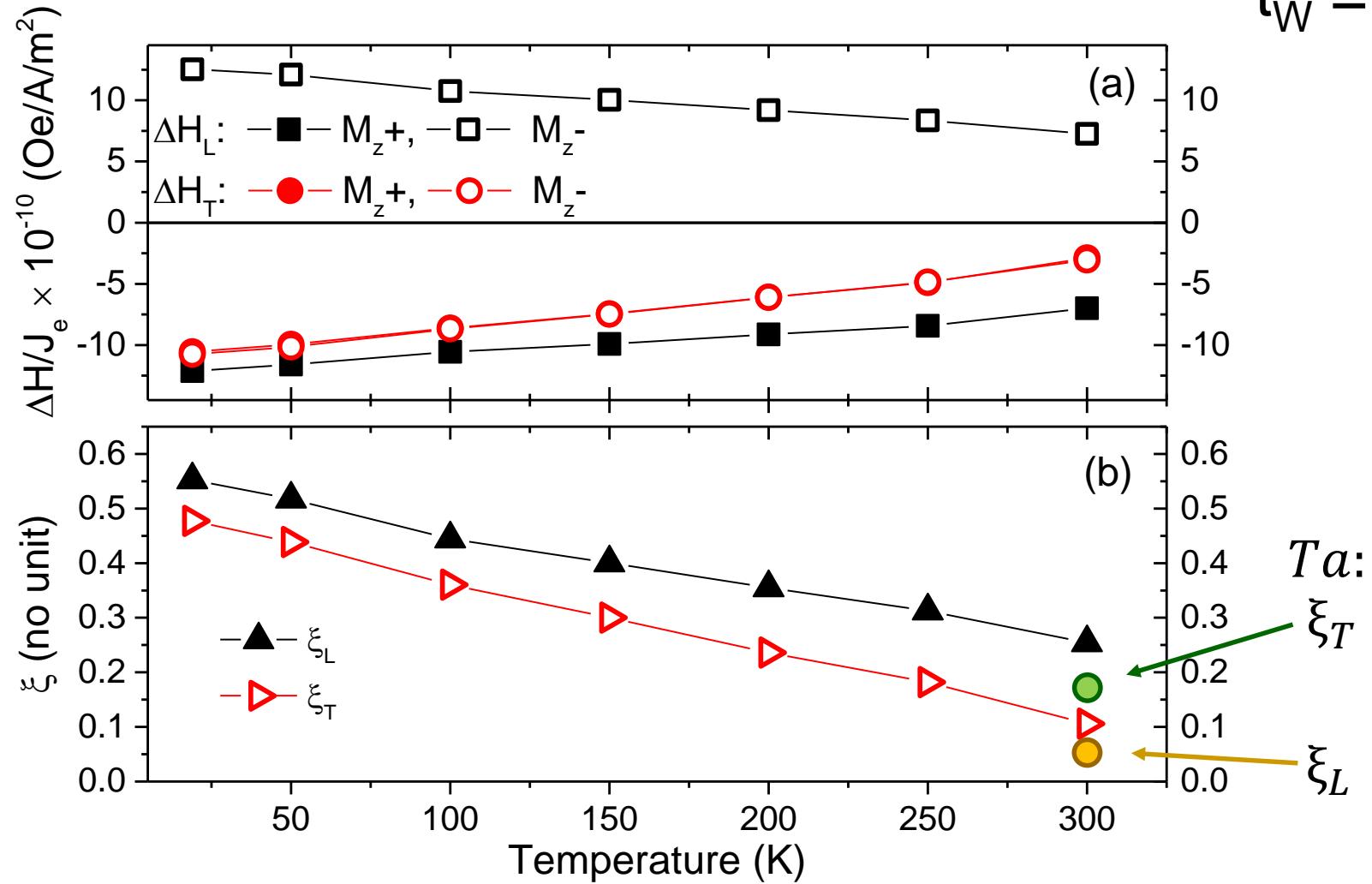
$$\Delta H_L = -2 \frac{(B_L \pm 2\xi B_T)}{1 - 4\xi^2},$$

$$\Delta H_T = -2 \frac{(B_T \pm 2\xi B_L)}{1 - 4\xi^2},$$

$$\xi \equiv \frac{\Delta R_P}{\Delta R_A}$$

# Spin Hall torque efficiencies in W

$t_W = 2 \text{ nm}$

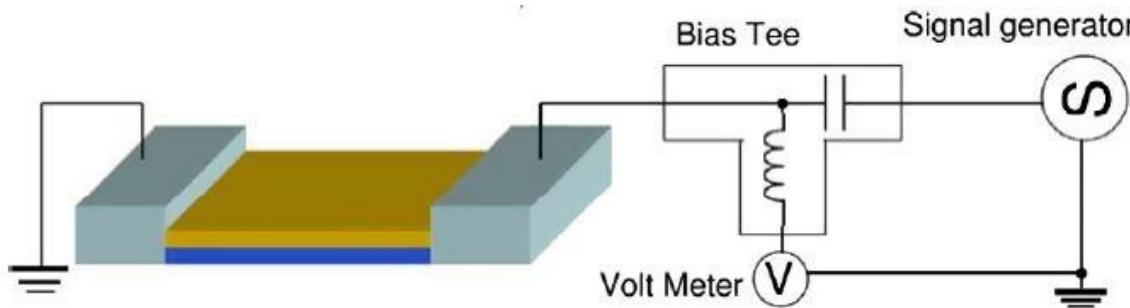


## SHE in W/CoFeB: summary

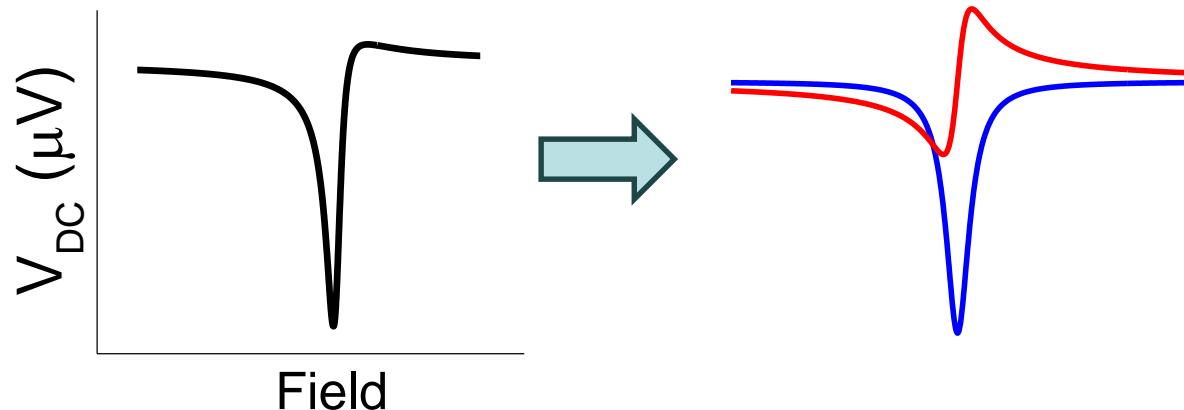
- ❖ Significant changes in the structure of W  
High resistive  $\beta$ -phase structure for 2 nm and 4 nm of W  
(above 100  $\mu\Omega\cdot\text{cm}$ ) and  $\alpha$ -phase for thicker layer (36  $\mu\Omega\cdot\text{cm}$ )
- ❖ Strong interdiffusion of W into CoFeB  
The lack of sharp interface
- ❖ Both Spin Hall torque efficiencies have the same temperature dependence  
Domination of antidamping torque

# SHE: second measurement method

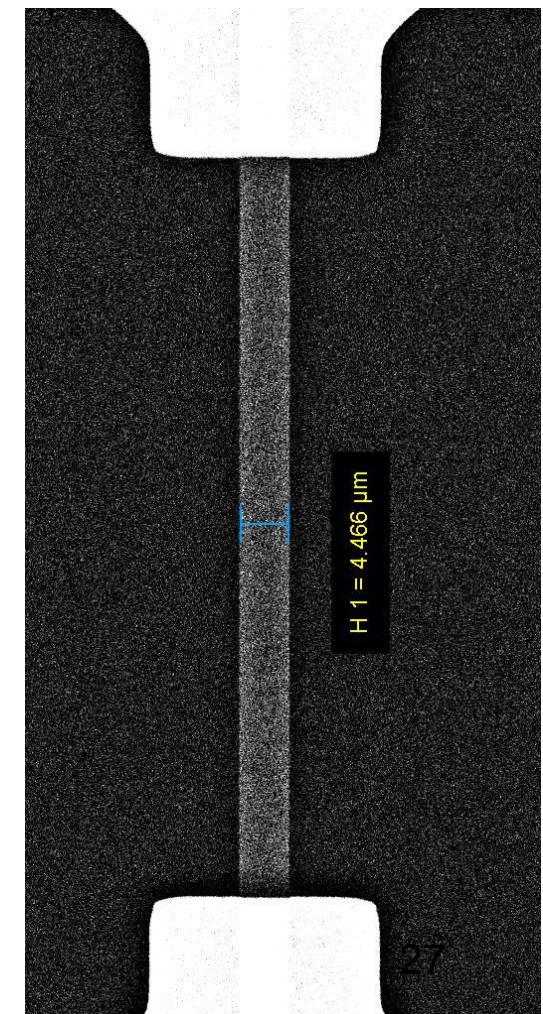
- Spin Diode Effect



Liu et al. PRL 106, 036601 (2011)



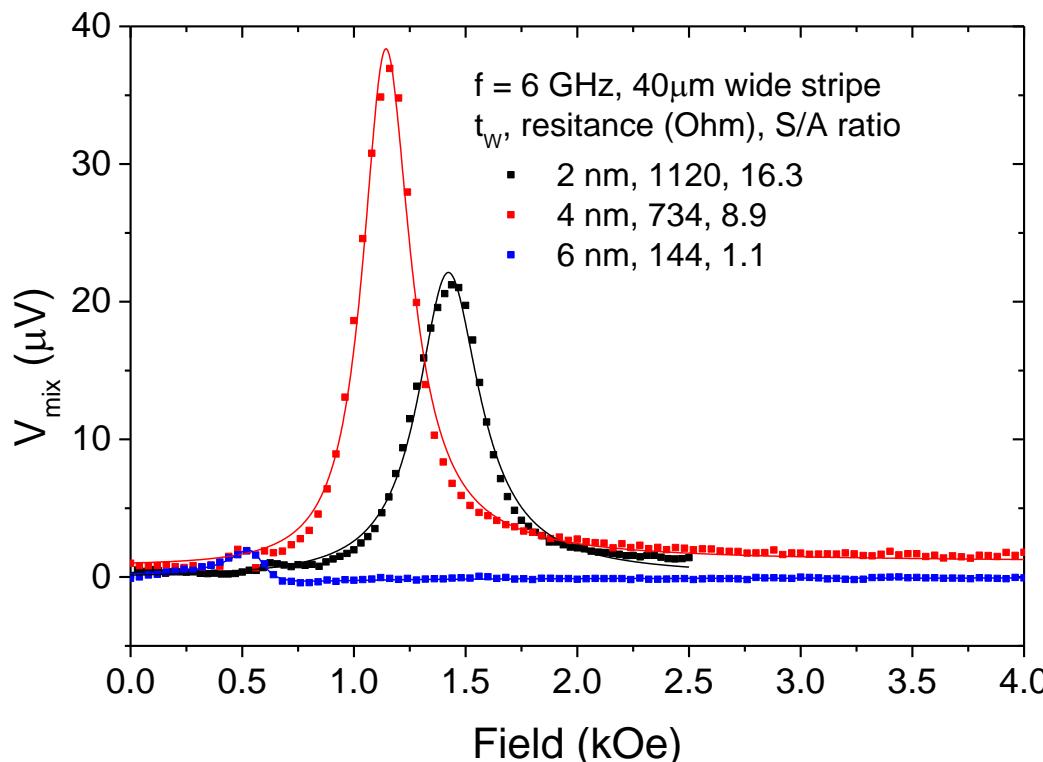
A direct voltage signal measured along the stripe comes from the RF current mixed with the oscillating resistance



# ST-FMR (Spin Diode Effect)

As-deposited:  
**d W / 1.5 CoFeB / 5 MgO / 4 Ta**  
**d W = 2 nm, 4 nm, 6 nm**

$$\theta_{SH} = \frac{J_s}{J_c} = \frac{S}{A} \times \frac{e\mu_0 M_s t d}{\hbar} \times \sqrt{1 + \left(\frac{M_{eff}}{H_0}\right)}$$



Liu et al. PRL 106, 036601 (2011)

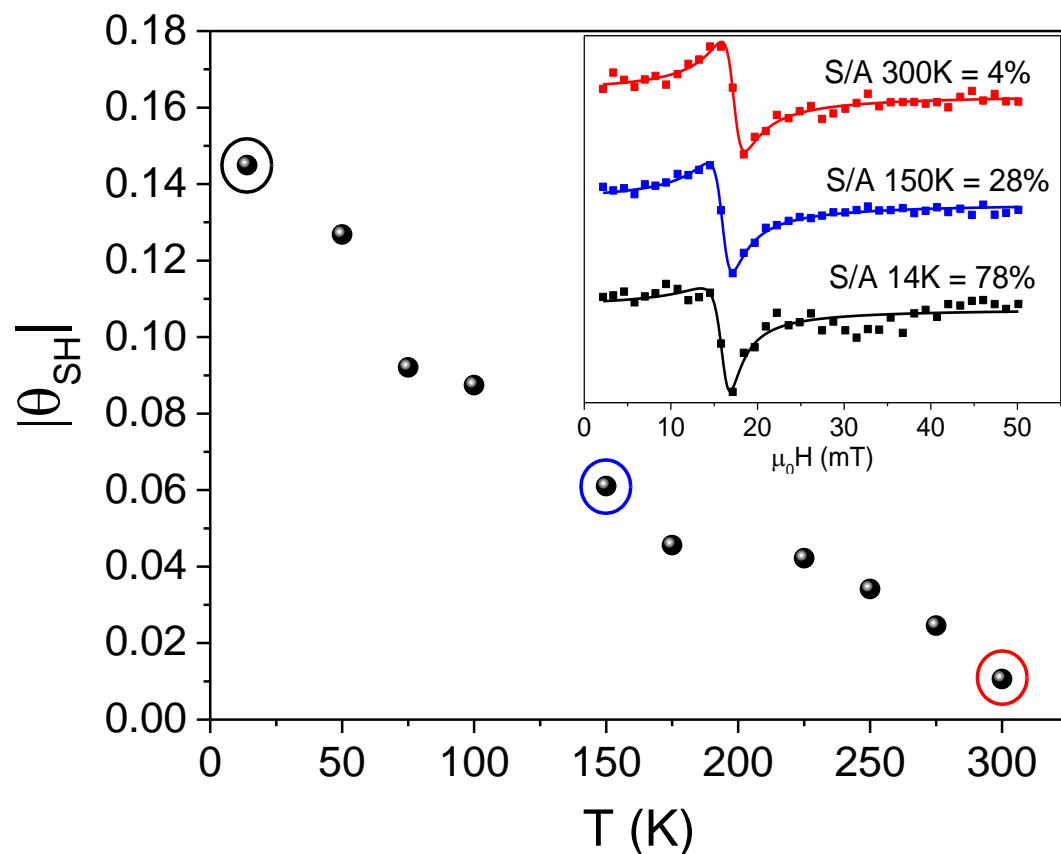
	<b>f (GHz)</b>	<b>4.00</b>	<b>5.00</b>	<b>6.00</b>	<b>Resistivity (μOhm*cm)</b>
<b>d (nm)</b>	2	0.13	0.13	0.16	<b>128</b>
	4	0.22	0.21	0.21	<b>110</b>
	6	0.05	0.06	0.05	<b>41</b>

AMR  $\sim 0.3$  %

# ST-FMR (Spin Diode Effect)

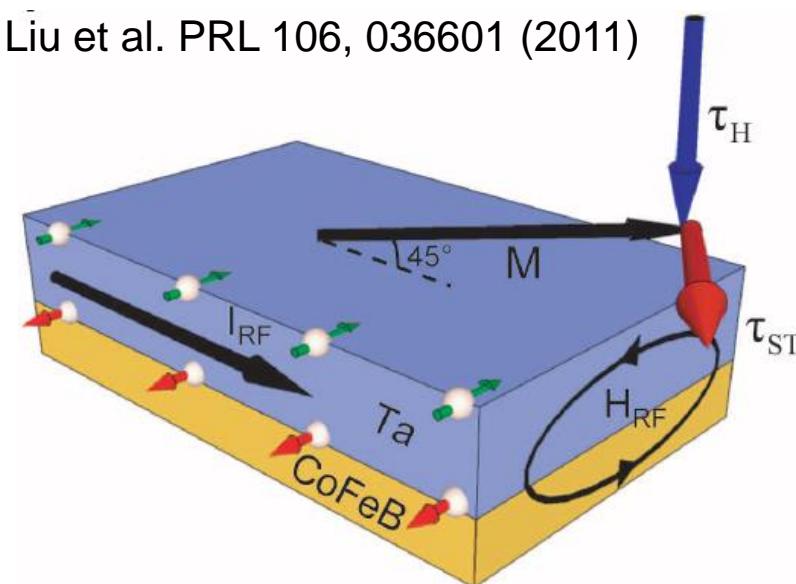
As-deposited:  
**d Ta / 2.5 CoFeB / 5 MgO / Al<sub>2</sub>O<sub>3</sub>**  
**d Ta = 5 nm, 10 nm, 15 nm**

Temperature dependence for  
**5 Ta / 2.5 CoFeB / 5 MgO / Al<sub>2</sub>O<sub>3</sub>**



$$\theta_{SH} = \frac{J_S}{J_C} = \frac{S}{A} \times \frac{e\mu_0 M_S t d}{\hbar} \times \sqrt{1 + \left(\frac{M_{eff}}{H_0}\right)}$$

Liu et al. PRL 106, 036601 (2011)



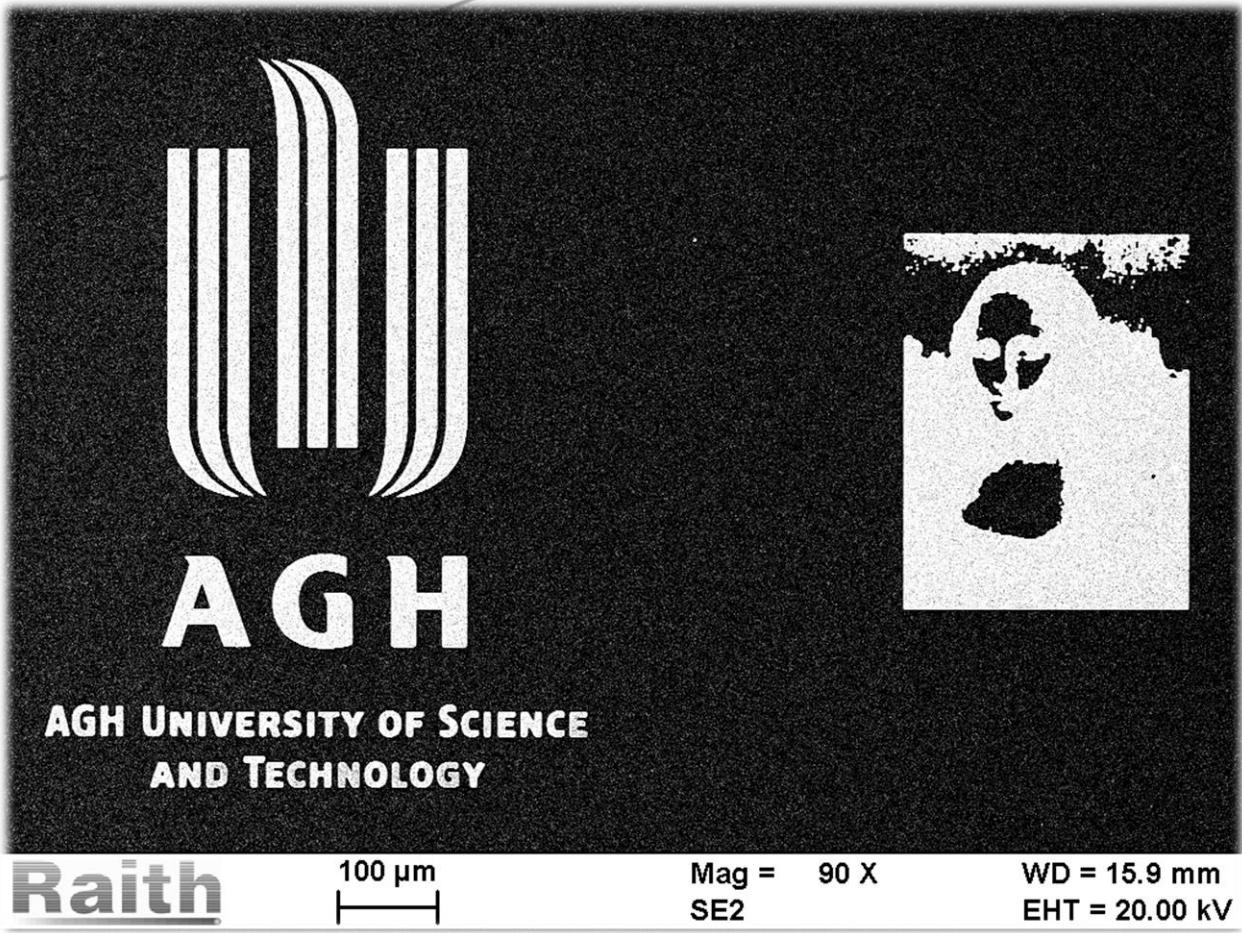
AMR ~ 0.1 %  
 effective damping  $\alpha \approx 0.006$

## SHE in samples with in-plane magnetization: summary

- ❖ Lack of compliance for Ta compared to other methods
- ❖ For W a better agreement with harmonic Hall voltage measurements

Hall angle for  $t_W = 2 \text{ nm}$  is 0.13 in spin diode measurements and 0.25 in harmonic method

- ❖ An influence of the several factors on shape of the line  
Field-like component, Oersted field from the electrodes and bottom metal layer



AGH UNIVERSITY OF SCIENCE  
AND TECHNOLOGY

Thank you for your  
kind attention!

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Swiss Contribution

